

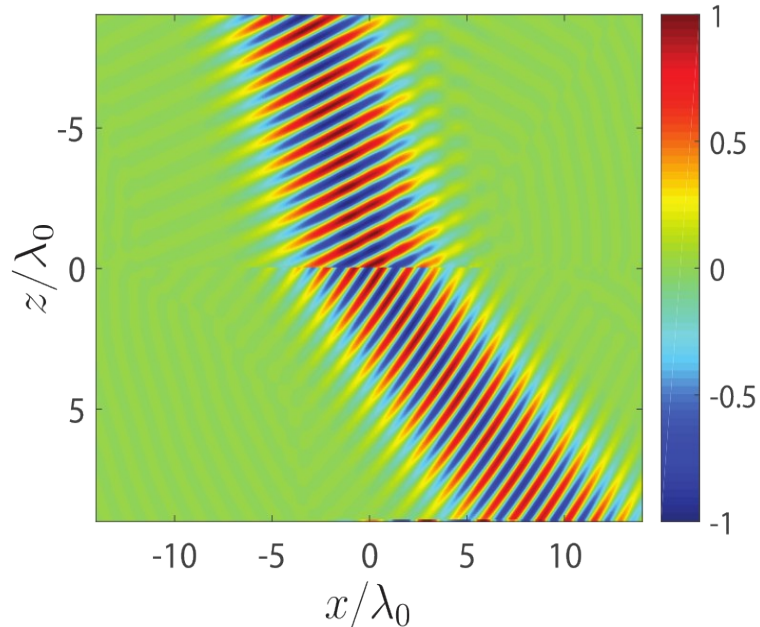
Lecture 14

Wave Control Strategies

Controlling the Phase is Important

Most metasurface wave transformations are based on controlling the phase

Refraction



Transfer function

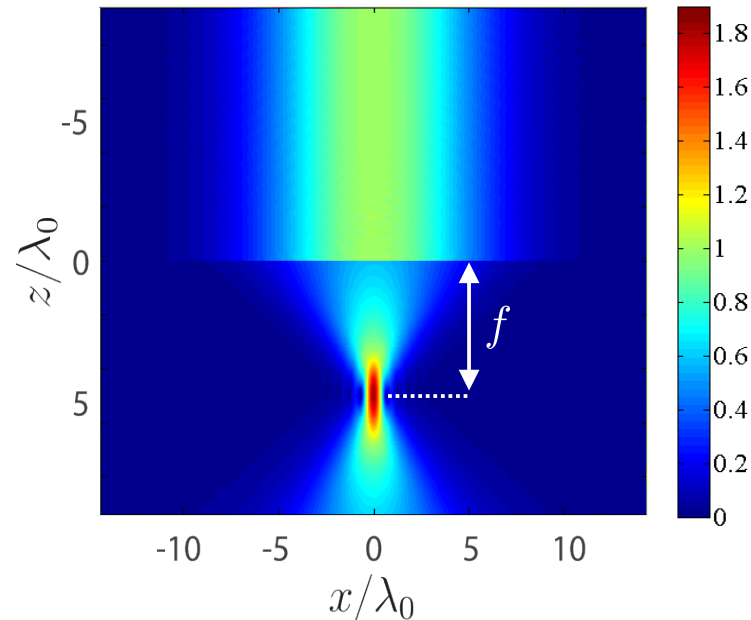
$$T = e^{-j(k_{x,t} - k_{x,i})x}$$

phase of scattered wave

$$T = \frac{\Phi_s}{\Phi_i}$$

phase of incident wave

Collimation



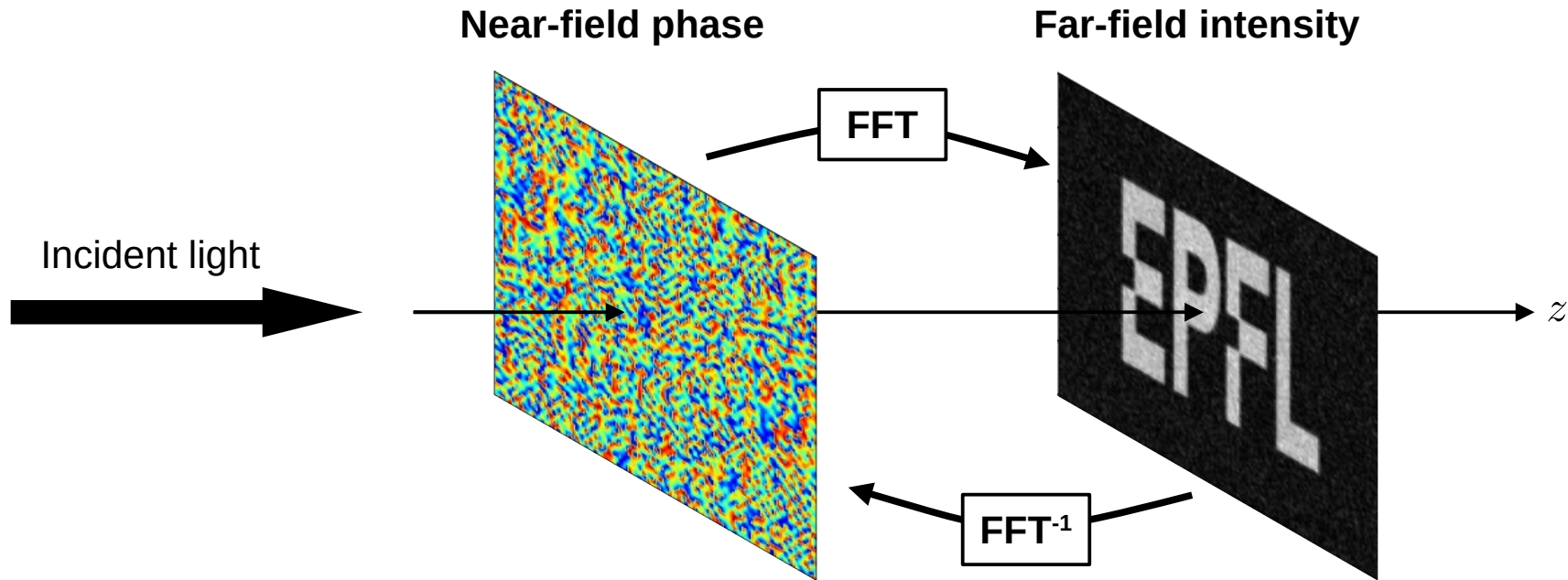
Transfer function

$$T = e^{-jk(\sqrt{x^2 + y^2 + f^2} - f)}$$

While approximate, this approach gives in practice decently good results.

Holography

Holography Concept



We know that the far-field of an aperture is proportional to the Fourier transform of the aperture field. We can therefore specify a target far-field intensity and determine the required near-field phase by using an inverse Fourier transform.

Gerchberg-Saxton Algorithm – First Step

Far field

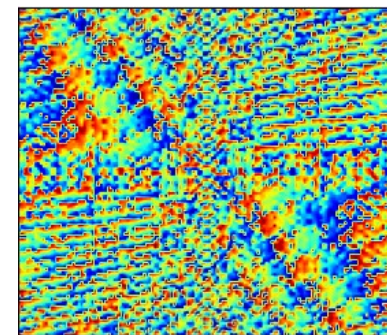
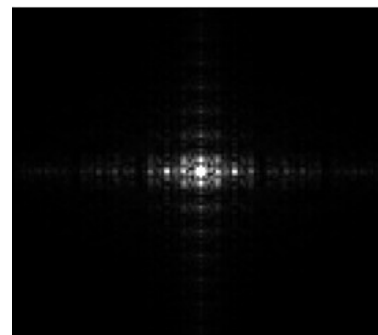
Near field

Intensity

Phase

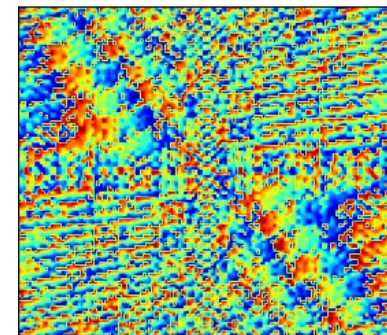
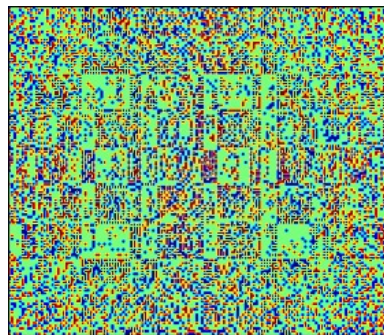
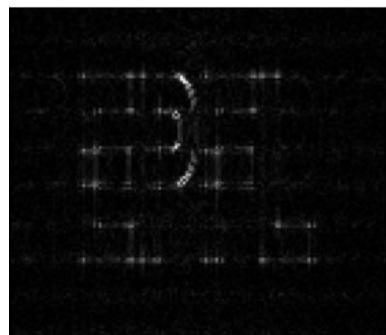
Intensity

Phase



Original target image

Corresponding complex near field



Reconstructed complex image

We only want to implement phase

Gerchberg-Saxton Algorithm – Second Step

Far field

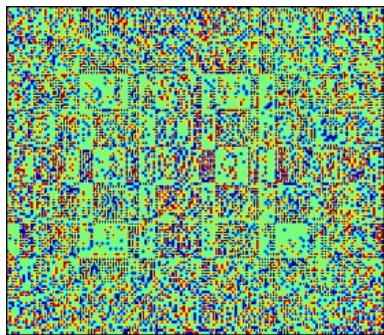
Near field

Intensity

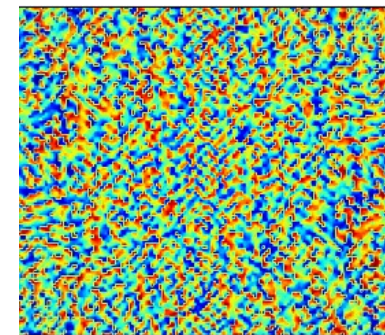
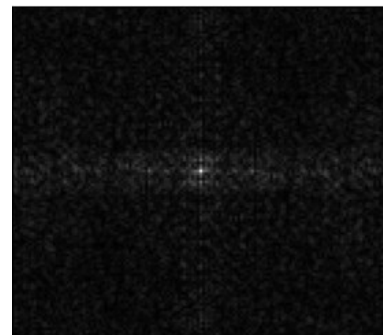
Phase

Intensity

Phase

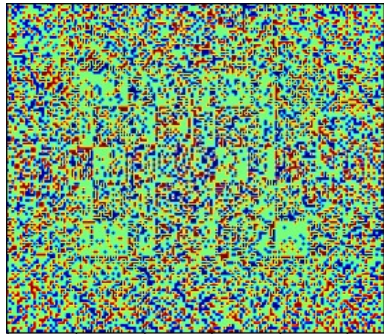


FFT⁻¹

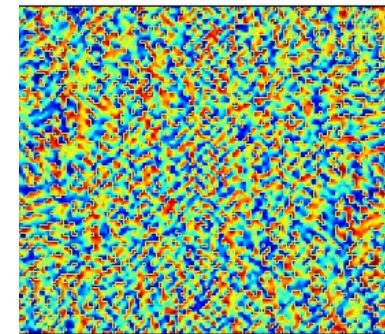
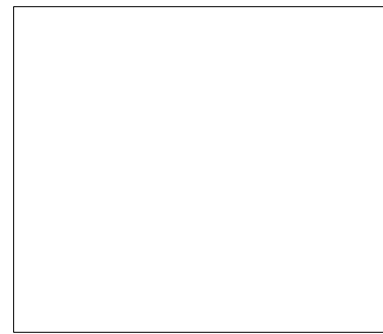


Original intensity with phase of previous step

Corresponding complex near field



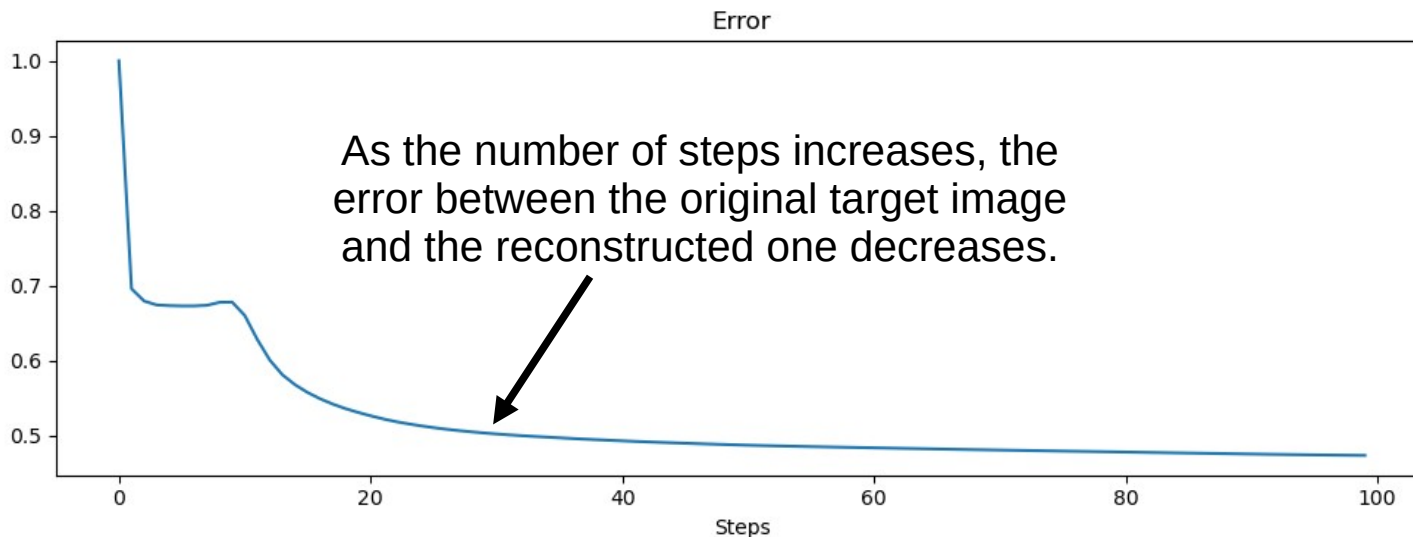
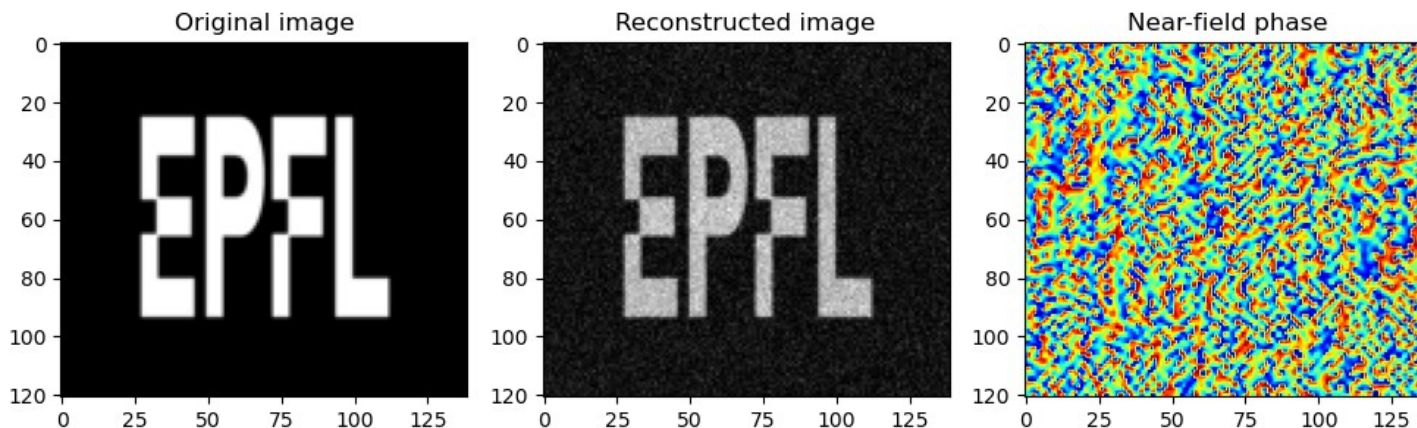
FFT



Reconstructed complex image

We only want to implement phase

Gerchberg-Saxton Algorithm – 100th Step



Python Implementation of the Gerchberg-Saxton Algorithm

```
from numpy import *
from matplotlib.pyplot import *
from PIL import Image

Nstep = 100
filename = 'EPFL.png'

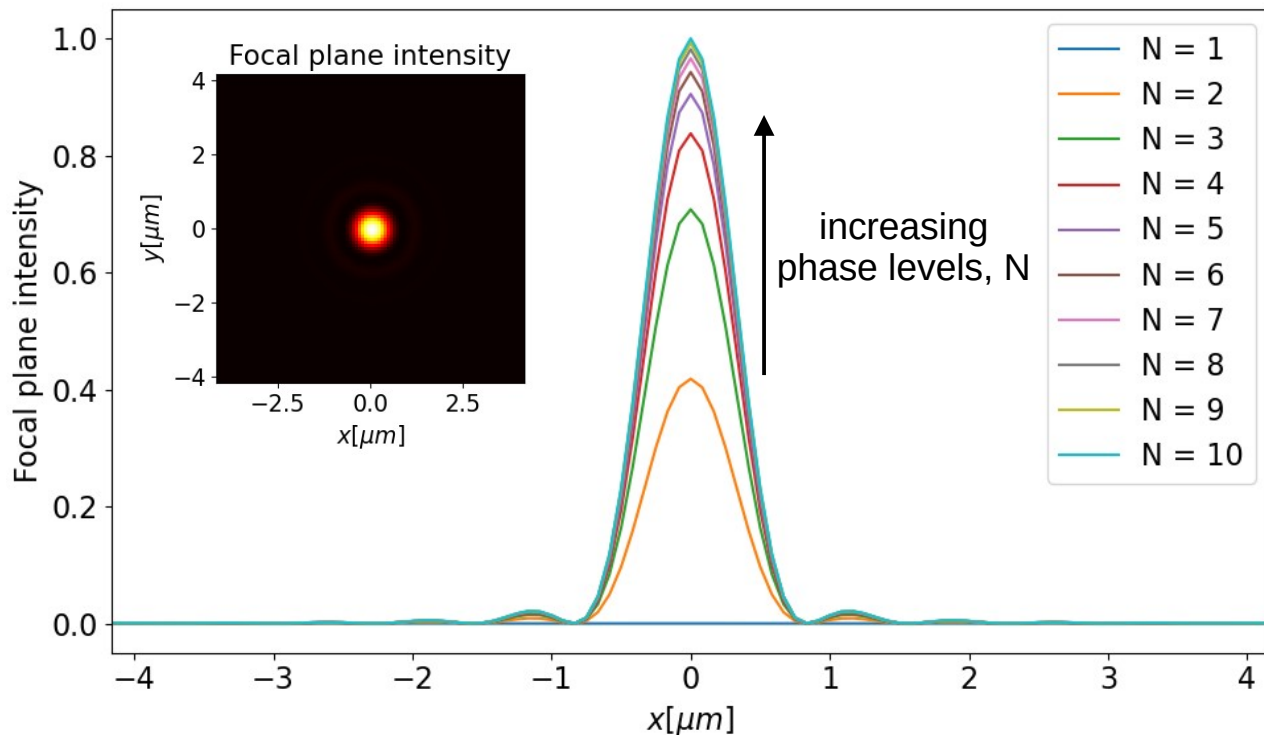
Im = asarray(Image.open(filename).convert('L'))
A = fft.fftshift(fft.ifft2(fft.fftshift(Im)))
err = zeros(Nstep)
for n in range(Nstep):
    B = exp(1j*angle(A)) # near-field phase
    C = fft.fftshift(fft.fft2(fft.ifftshift(B))) # far-field image
    D = abs(Im)*exp(1j*angle(C)) # update far-field phase
    A = fft.fftshift(fft.ifft2(fft.ifftshift(D))) # new near field
    err[n] = sum(abs(abs(C) - abs(Im)))

figure(figsize=(10,7))
subplot(231)
imshow(Im, cmap='gray')
title('Original image')
subplot(232)
imshow(abs(C), cmap='gray')
title('Reconstructed image')
subplot(233)
imshow(angle(A), cmap='jet')
title('Near-field phase')
subplot(212)
plot(err/max(err))
xlabel('Steps')
title('Error')
tight_layout()
show()
```

Implementation of Phase Controlling Structures

Phase Discretization

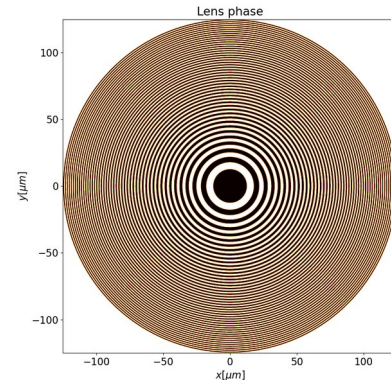
Wavelength: 632 nm, lens diameter: 250 μm , focal length: 250 μm



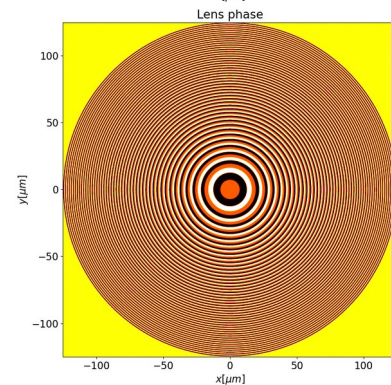
We need at least 5 phase levels to achieve 90% of maximum efficiency

$$\text{Resolution limit: } R \approx 1.22\lambda \frac{f}{D}$$

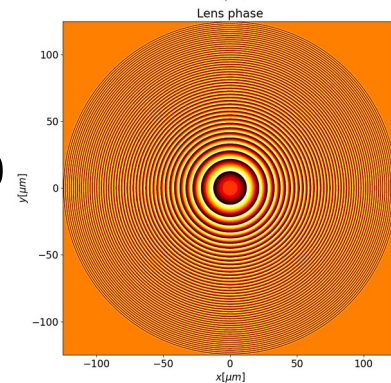
$N = 2$



$N = 3$

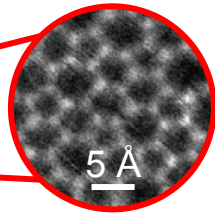
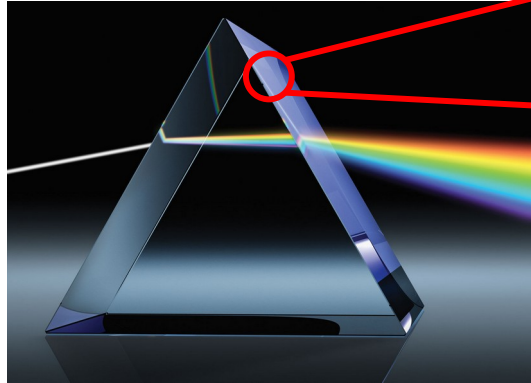


$N = 10$



Metasurface Electromagnetic Properties

Conventional Material

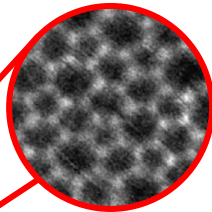
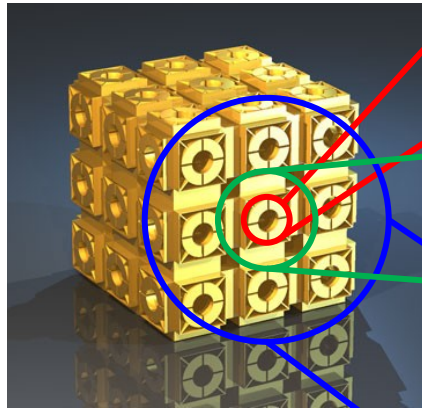


Amorphous silica (TEM)

Electromagnetic properties due to **chemical** composition

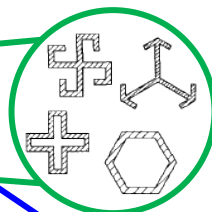
Electromagnetic properties due to **chemical** composition, **shape** of scatters and **lattice** arrangement

Metamaterial



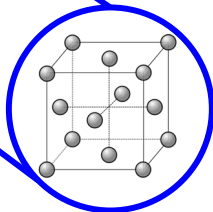
Material

size $< \lambda/1000$



Shape

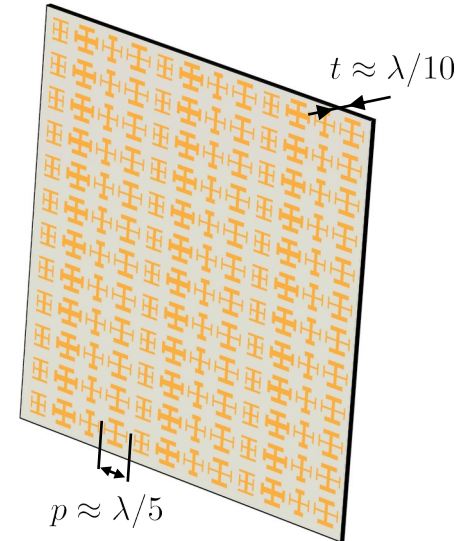
size $< \lambda/5$



Lattice

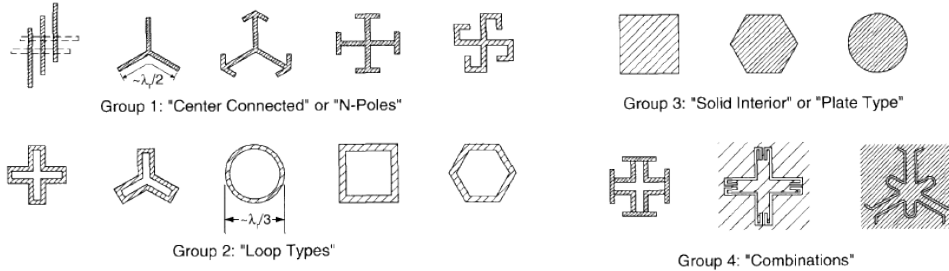
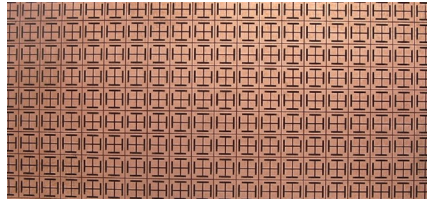
size $< \lambda/2$

Metasurface

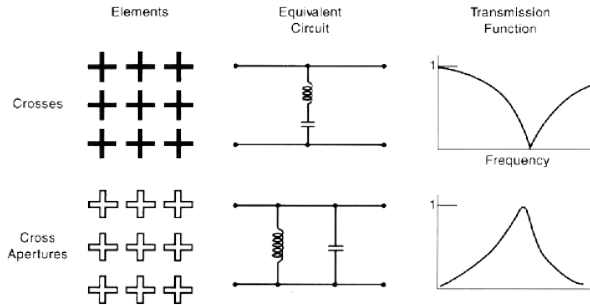


Controlling the Phase is Important

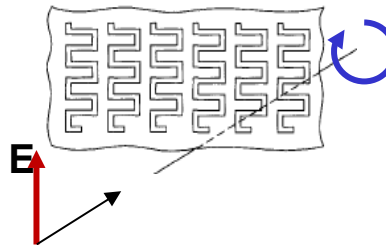
Scatterer Types



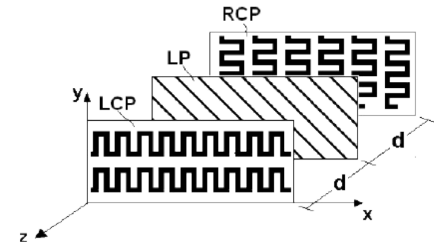
Spatial Filtering of Temporal Frequencies



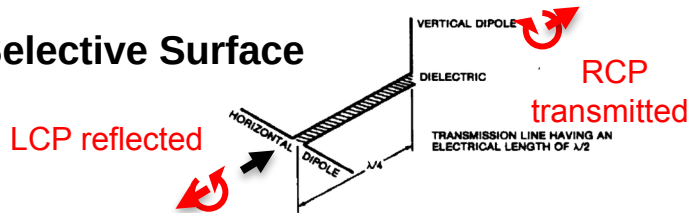
Polarization Transformers



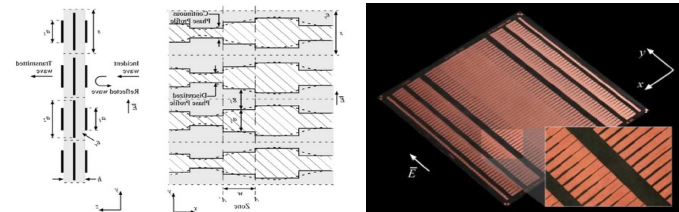
Multilayer BW Enhancement



CP Selective Surface

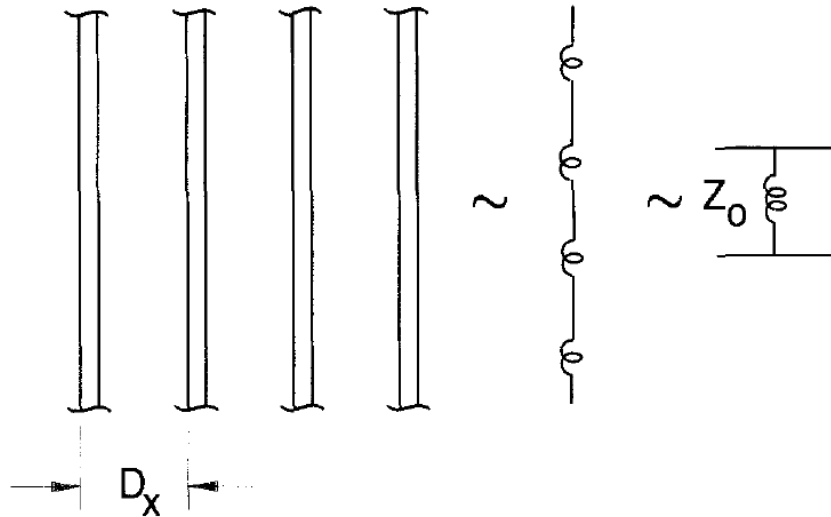


Beamforming Transmit Array



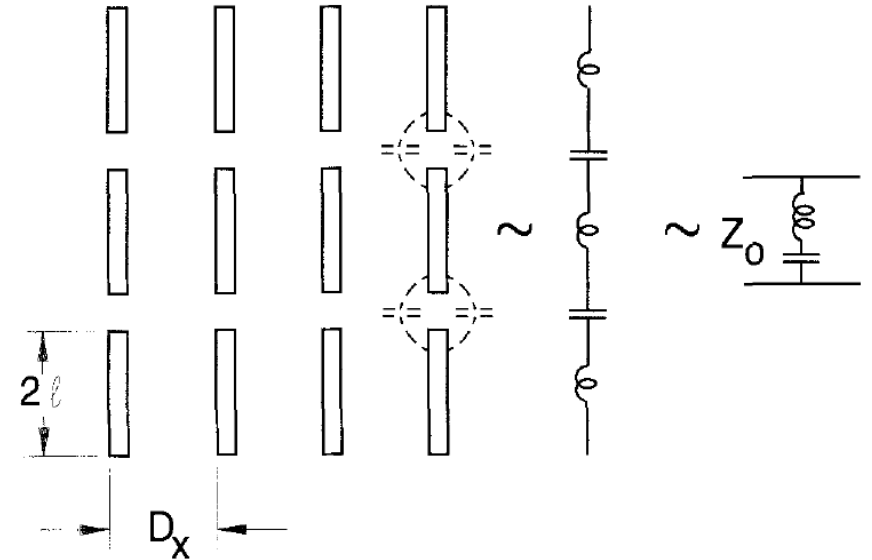
A Note About Resonance

Array of long metallic strips



Modeled as an effective inductance => does not resonate

Array of metallic patches



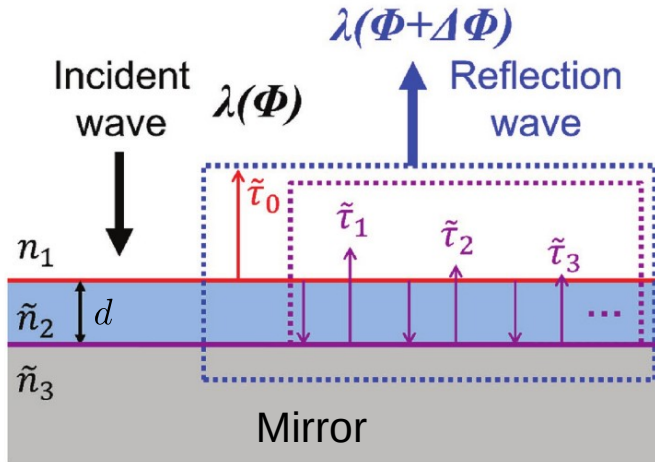
Modeled as an effective LC circuit => resonates

What Have We Learned So Far....

- Most metasurfaces are designed to control the phase of the light.
- Indeed, most metasurface applications consist in implementing transfer functions based on two-dimensional phase shifts.
- One of the most well-known applications is that of holography that can be realized with the Gerchberg-Saxton algorithm.
- To implement a metasurface, one must discretize its transfer function. The more discretization levels, the smaller the spatial variations of the transfer function that can be implemented and the higher the efficiency. However, the smaller the unit-cells, the less they interact with the fields and the harder it is to realize them.
- To implement a unit-cell, there are three levels of control: 1) material, 2) shape and 3) lattice.
- Disconnected unit-cells resonate like LC resonators, whereas connected unit-cells typically do not resonate.
- Resonating unit-cells tend to be smaller than $\lambda/2$ due to the capacitive coupling in the array.

Gires-Tournois Effect

Gires-Tournois Effect



reflection coefficient

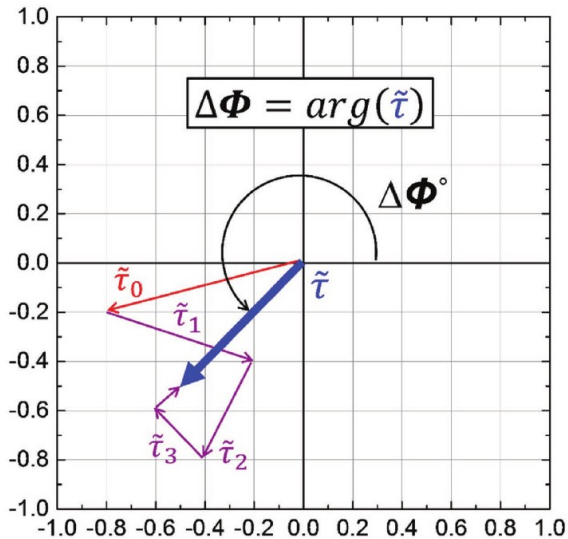
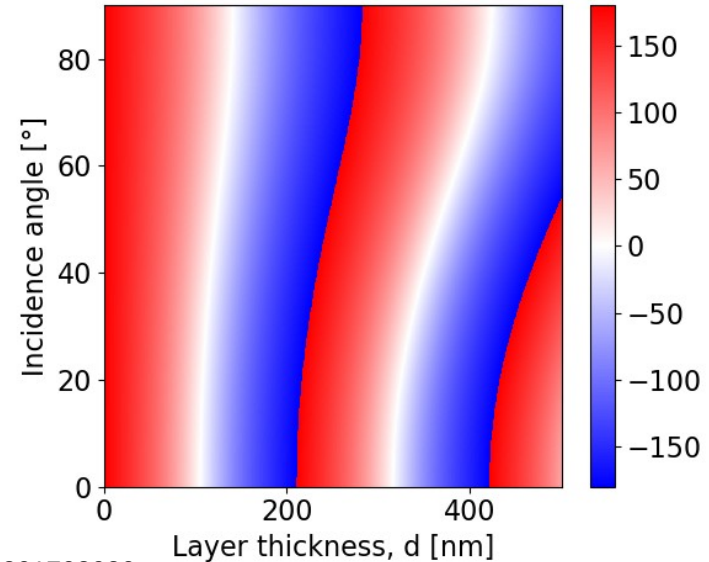
$$r = \frac{r_{12} + r_{23}e^{-j2\Psi}}{1 + r_{12}r_{23}e^{-j2\Psi}}$$

$$\Psi = k_0 n_2 d \cos \theta_2$$

θ_2 : refraction angle into n_2

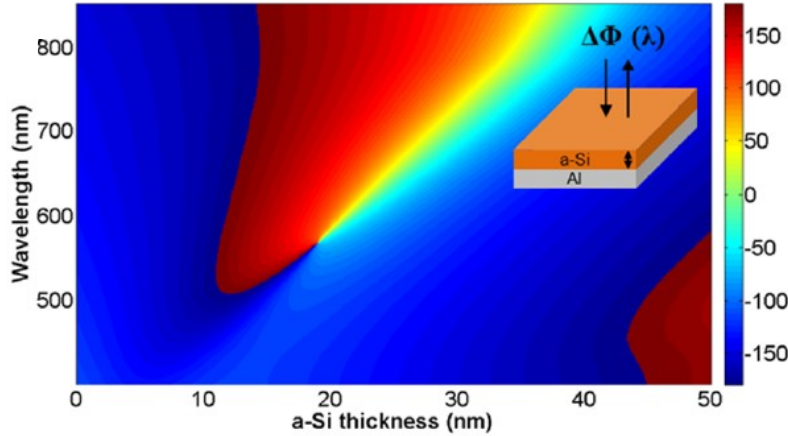
Example: $n_2 = 1.5$, $r_{23} = -1$

Reflection phase

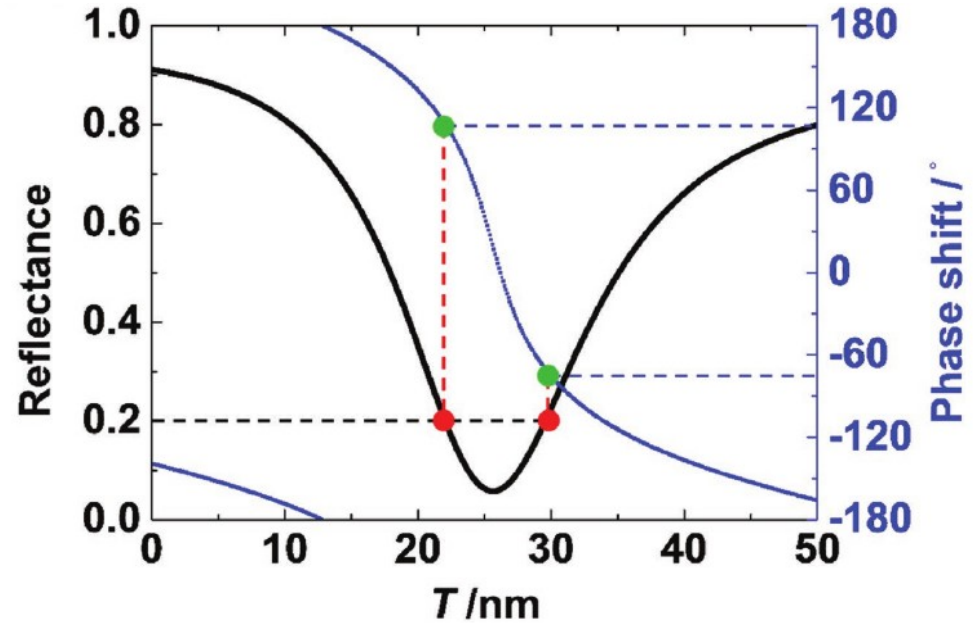
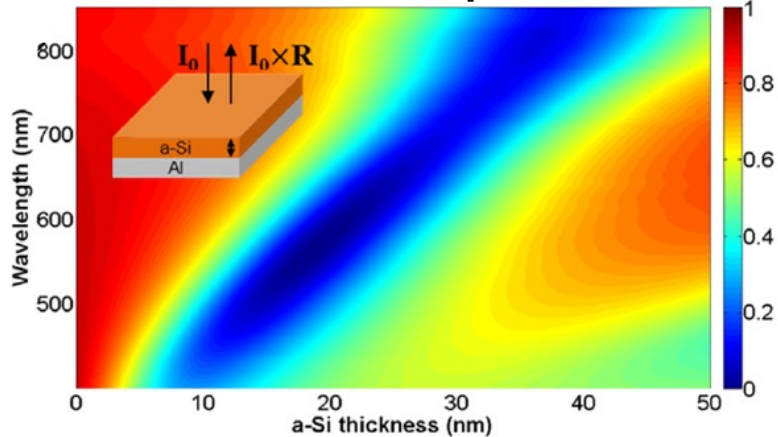


Gires-Tournois Effect with Subwavelength Thickness

Reflection phase

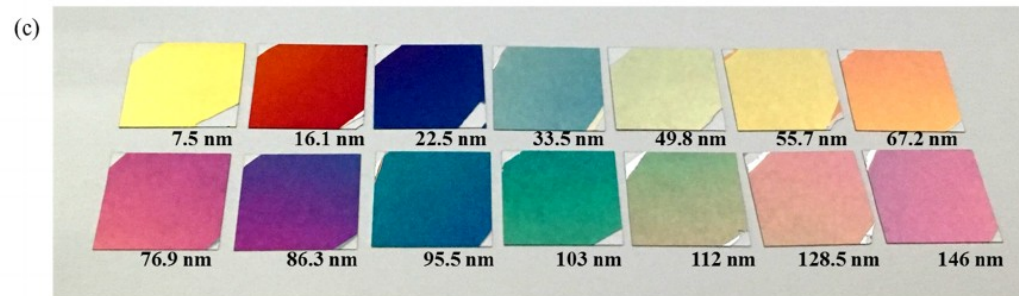
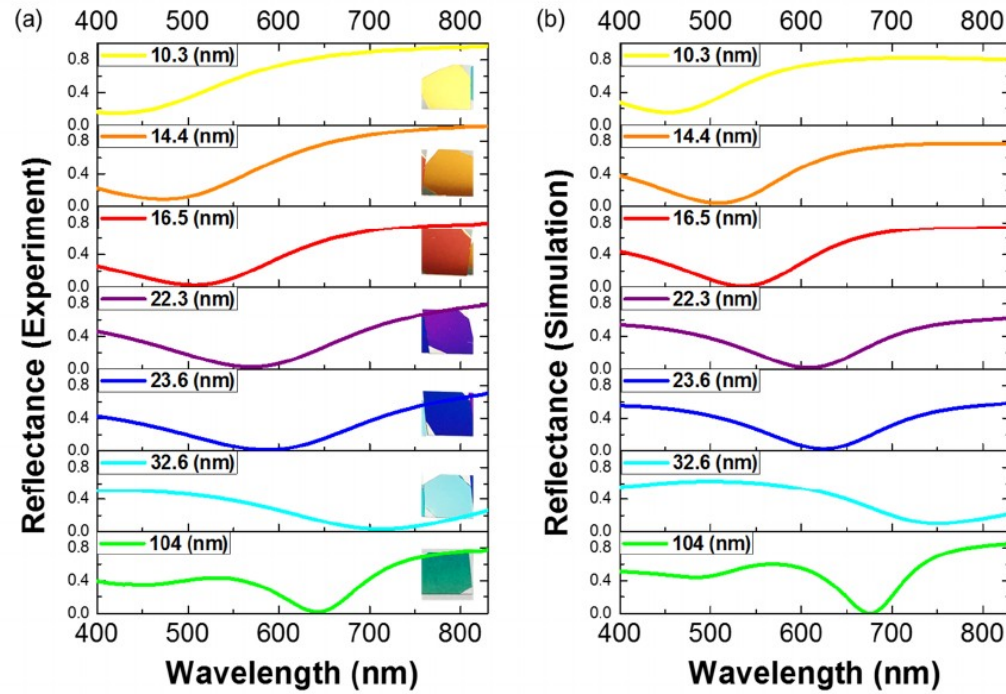


Reflection amplitude



We select two thicknesses with the same reflectance and π -phase shift difference to create binary phase structures.

Color Generation via Film Thickness



Binary-Phase Reflective Lens

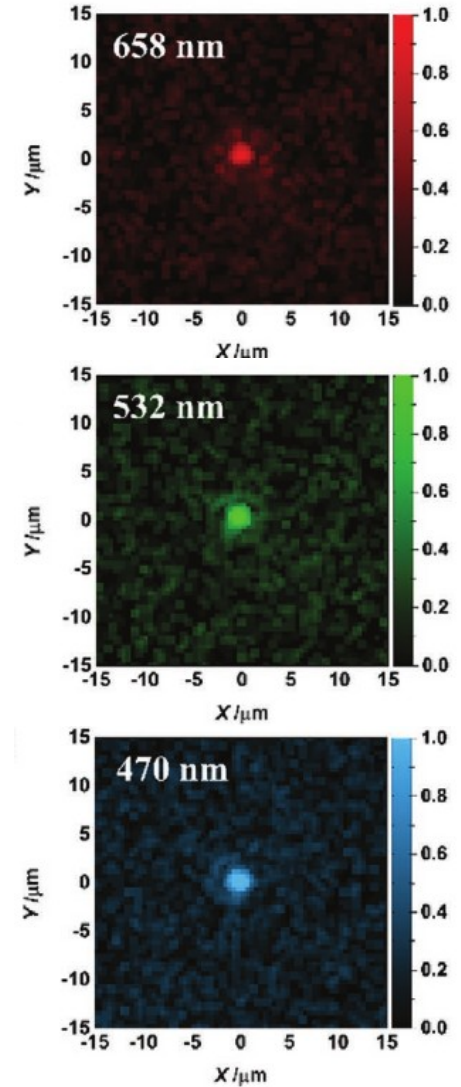
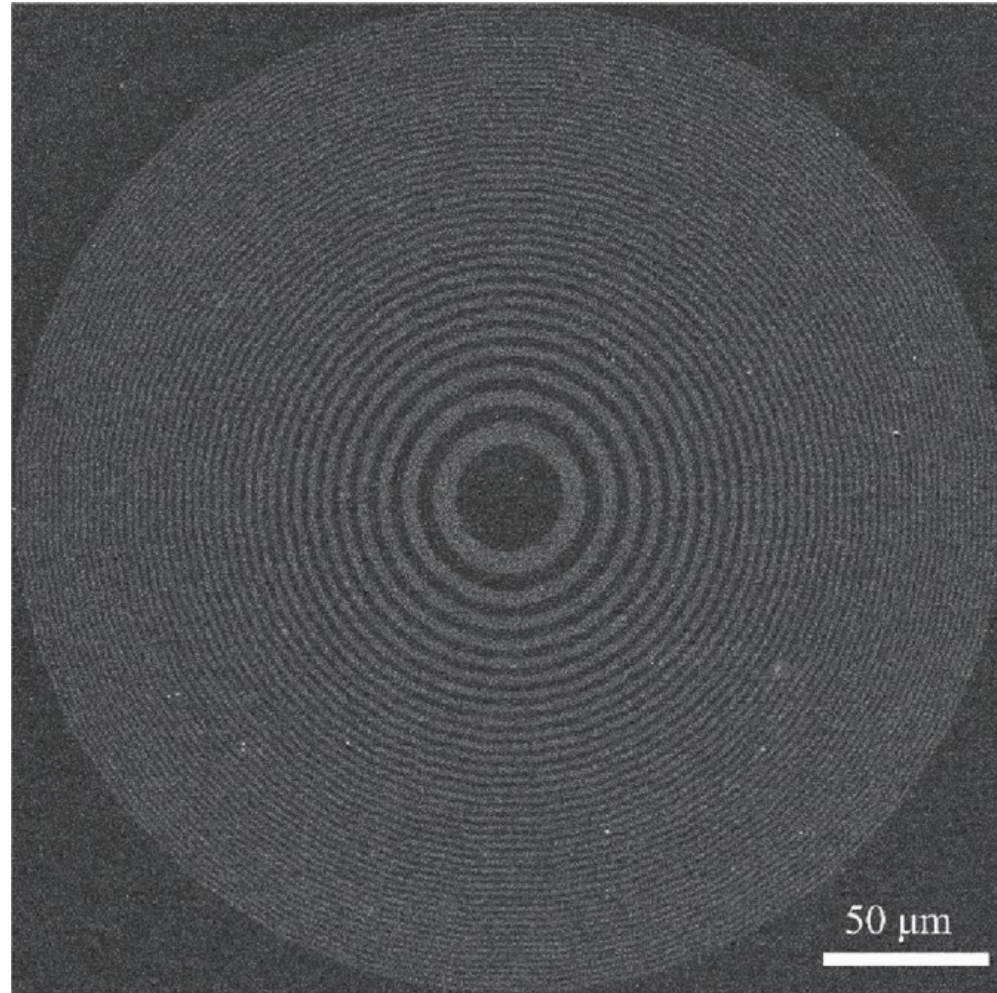
Transfer function

$$T = e^{-jk(\sqrt{x^2+y^2+f^2}-f)}$$

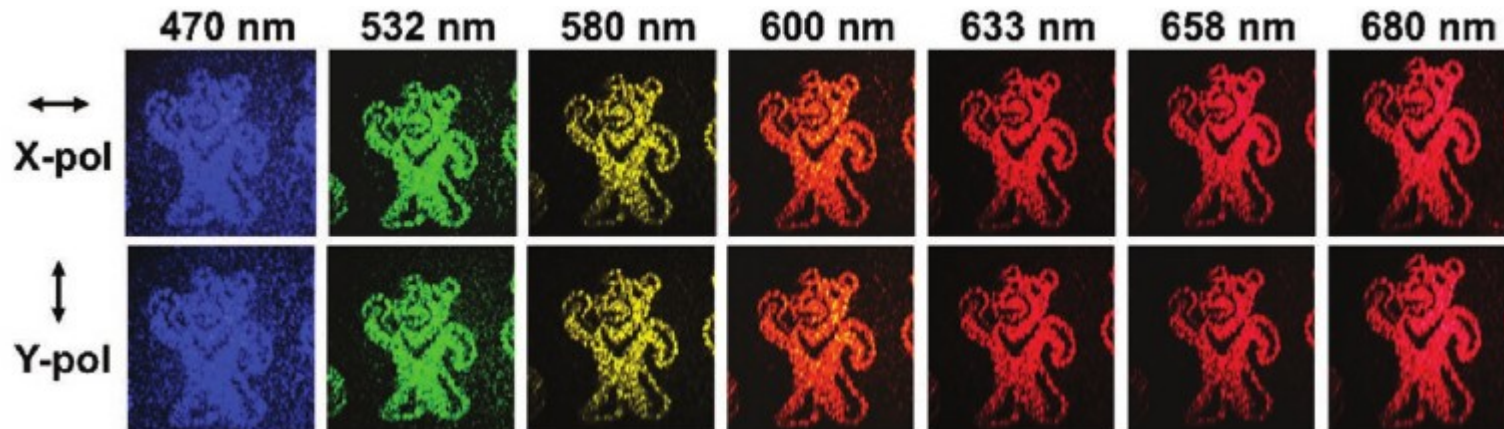
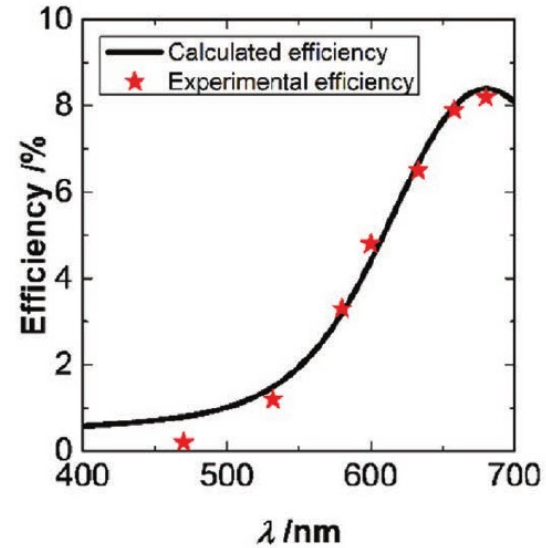
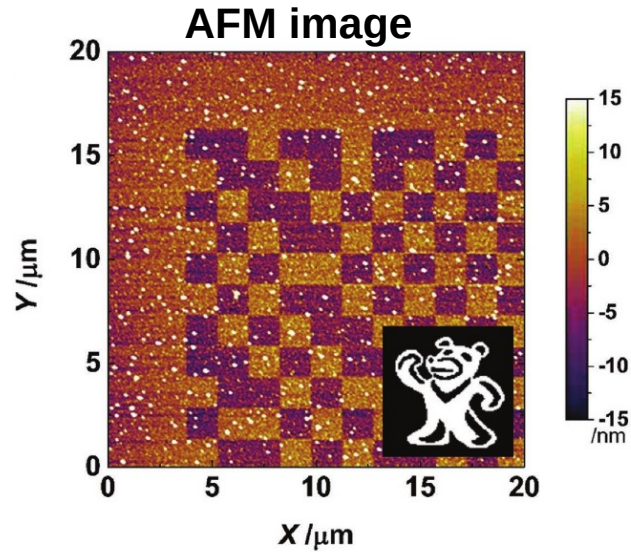
Designed wavelength = 658 nm

Diameter = 300 μm

Focal length = 400 μm



Binary-Phase Hologram



This is not a New Concept

Reflectarray made of open-ended waveguides of various length in 1963

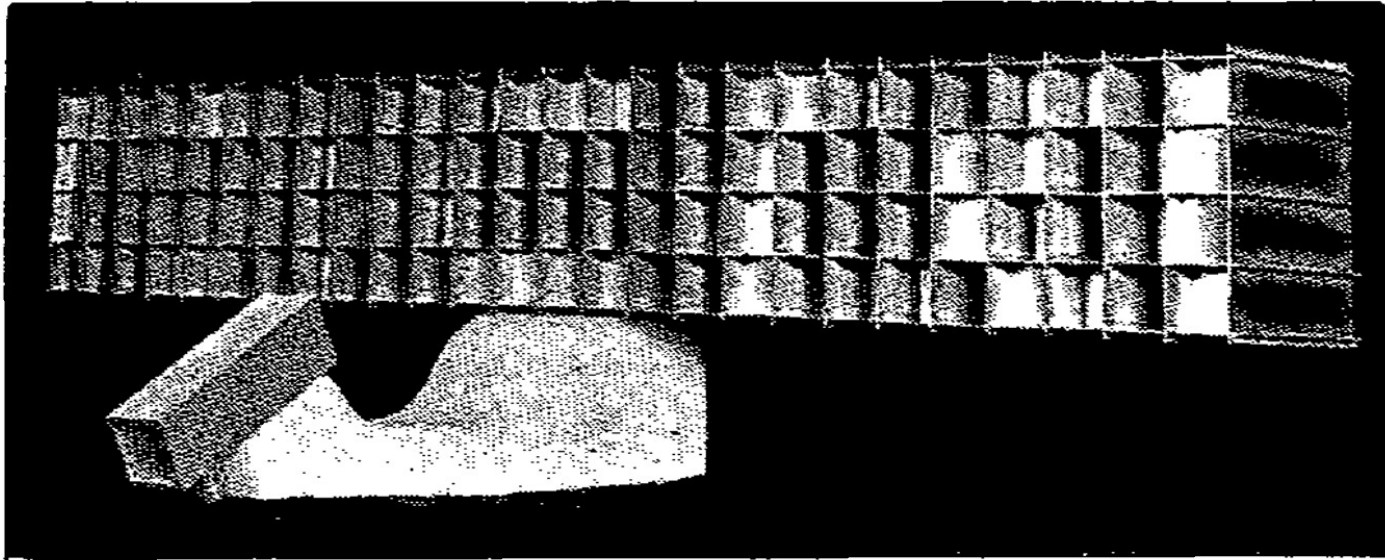
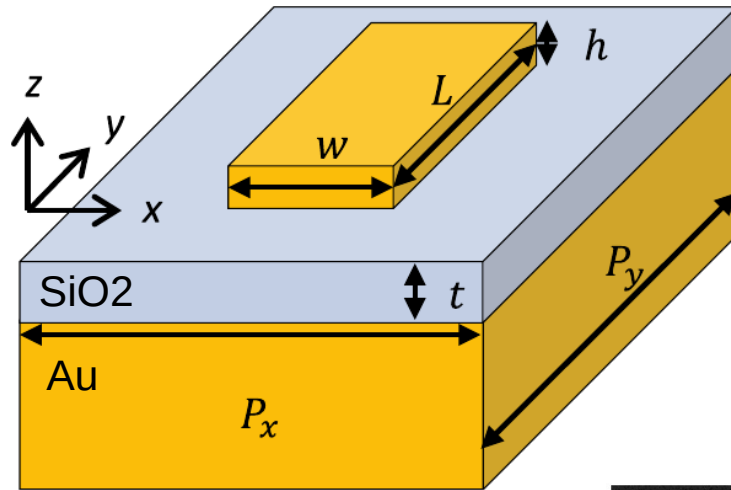


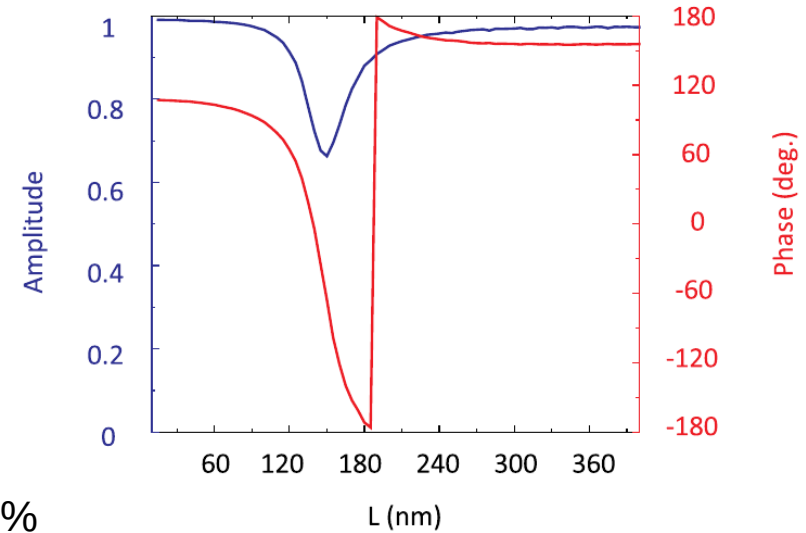
Fig. 3—Experimental model of the waveguide array type Reflectarray.

Refractive Metasurface without Changing the Height

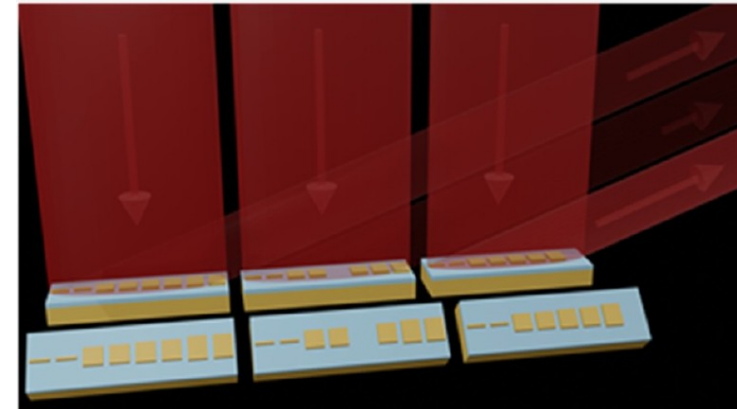
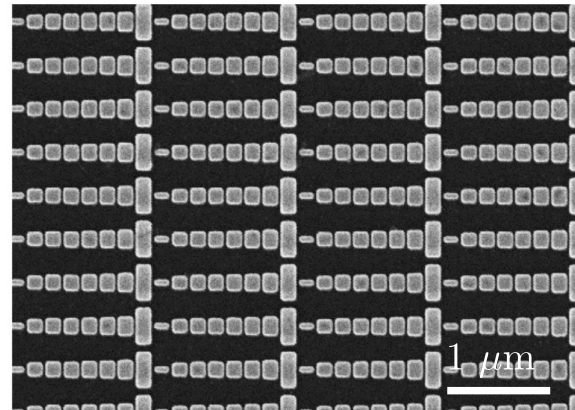
Tuning the size of the gold patch leads to an effect similar as tuning the thickness of the SiO₂ layer



Unit-cell reflection amplitude and phase



Efficiency ~60%



Parameters

$$\lambda = 980 \text{ nm}$$

$$h = 30 \text{ nm}$$

$$t = 40 \text{ nm}$$

$$w = 140 \text{ nm}$$

$$P_x = 180 \text{ nm}$$

$$P_y = 430 \text{ nm}$$

What Have We Learned So Far....

- One of the simplest way to realize 2π phase shift is to use reflective layers of various heights.
- This approach is however not easy to implement in the optical regime due to the limitations of nano-fabrication techniques.
- In optics, this approach can be used to implement binary phase structures, which necessarily implies low efficiency.
- Besides realizing phase shifts, it is an interesting method for generating colors.
- Instead of changing the height of the layer, it is possible to tune its effective response by changing the lateral dimensions of a metallic patch on top of it. This allows creating more discretized phase levels.

Electric and Magnetic Phase Control

Achieving 2π Phase Shift

Scattering parameters

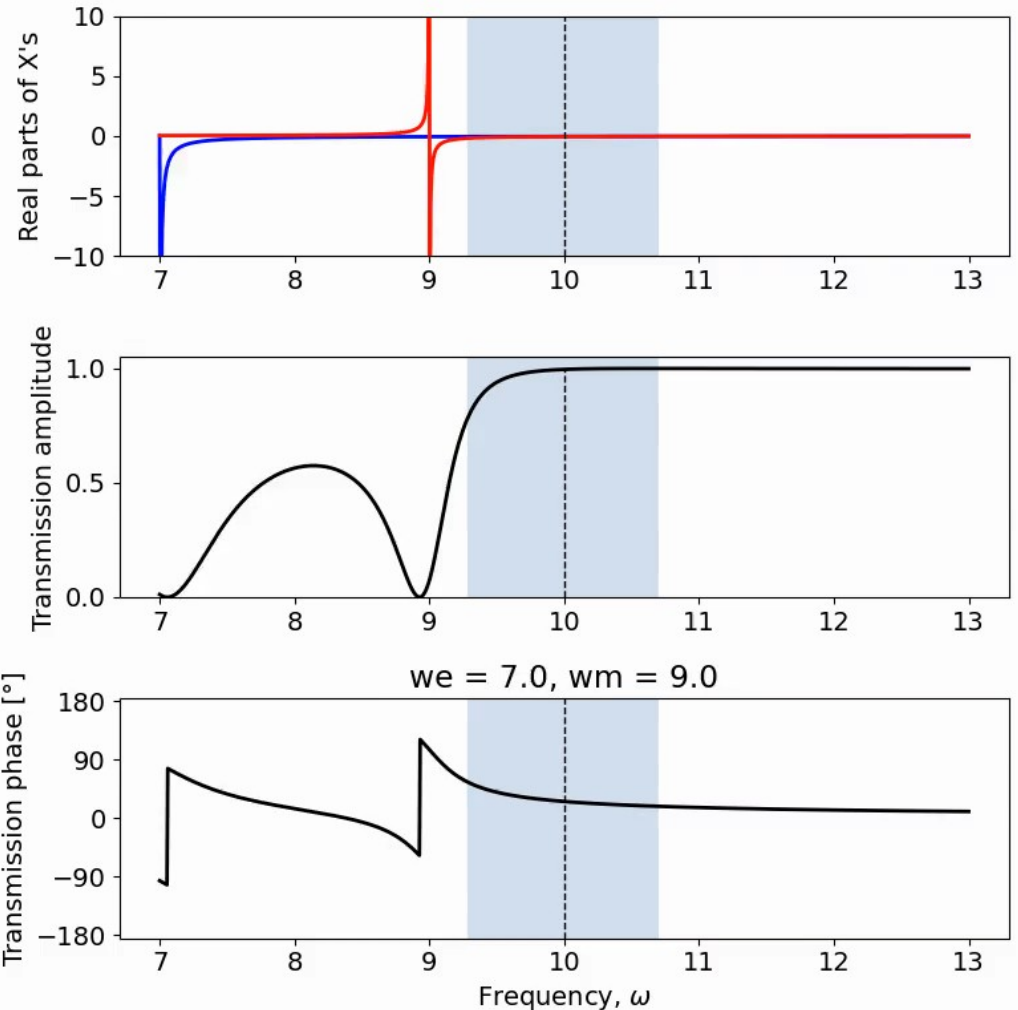
$$t = 1 - f_m - f_e$$

$$r = f_m - f_e$$

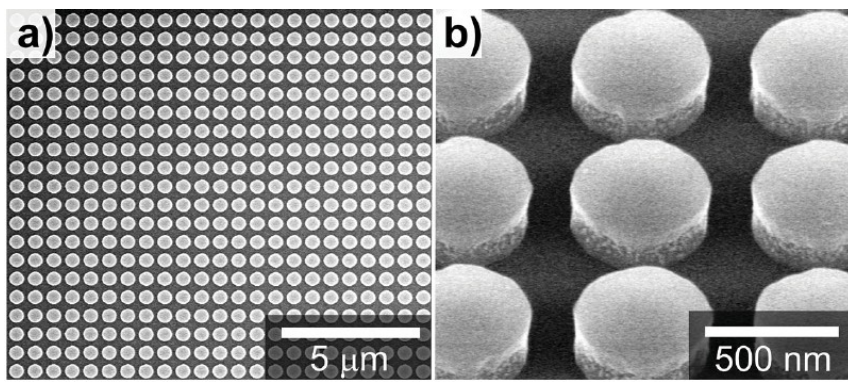
$$f_e = \frac{A_e k}{A_e k - 2\gamma_e \omega + 2j(\omega - \omega_e)(\omega + \omega_e)}$$

$$f_m = \frac{A_m k}{A_m k - 2\gamma_m \omega + 2j(\omega - \omega_m)(\omega + \omega_m)}$$

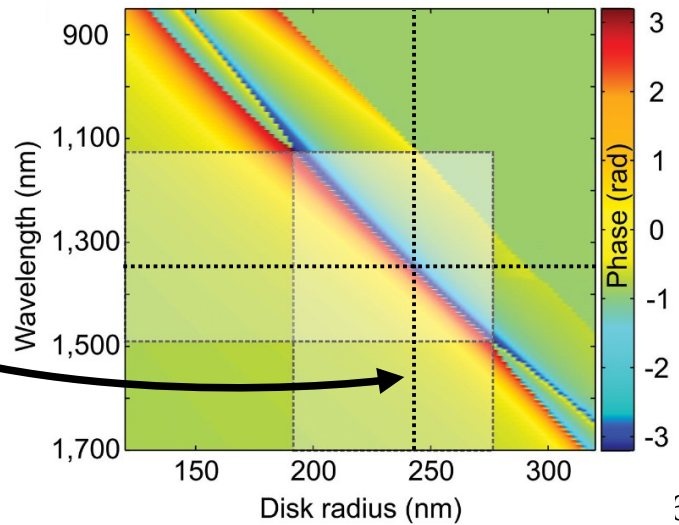
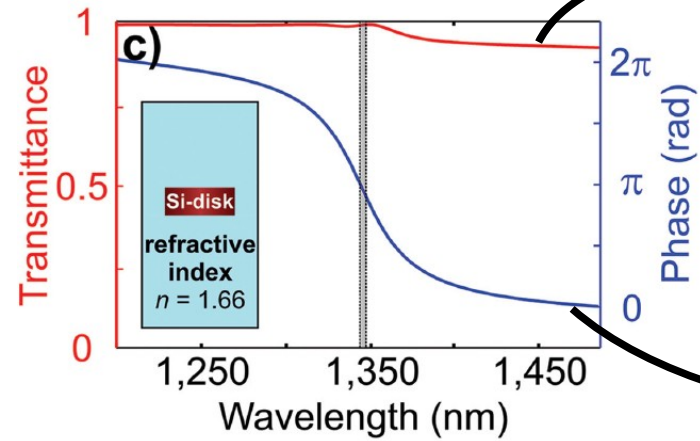
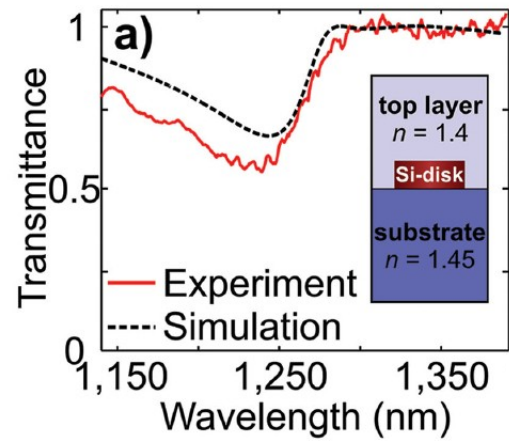
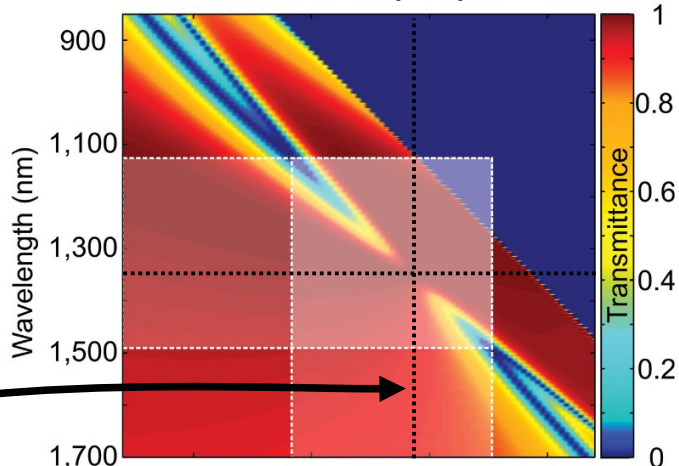
When the electric and magnetic resonances are close enough their interaction leads to a 2π phase shift



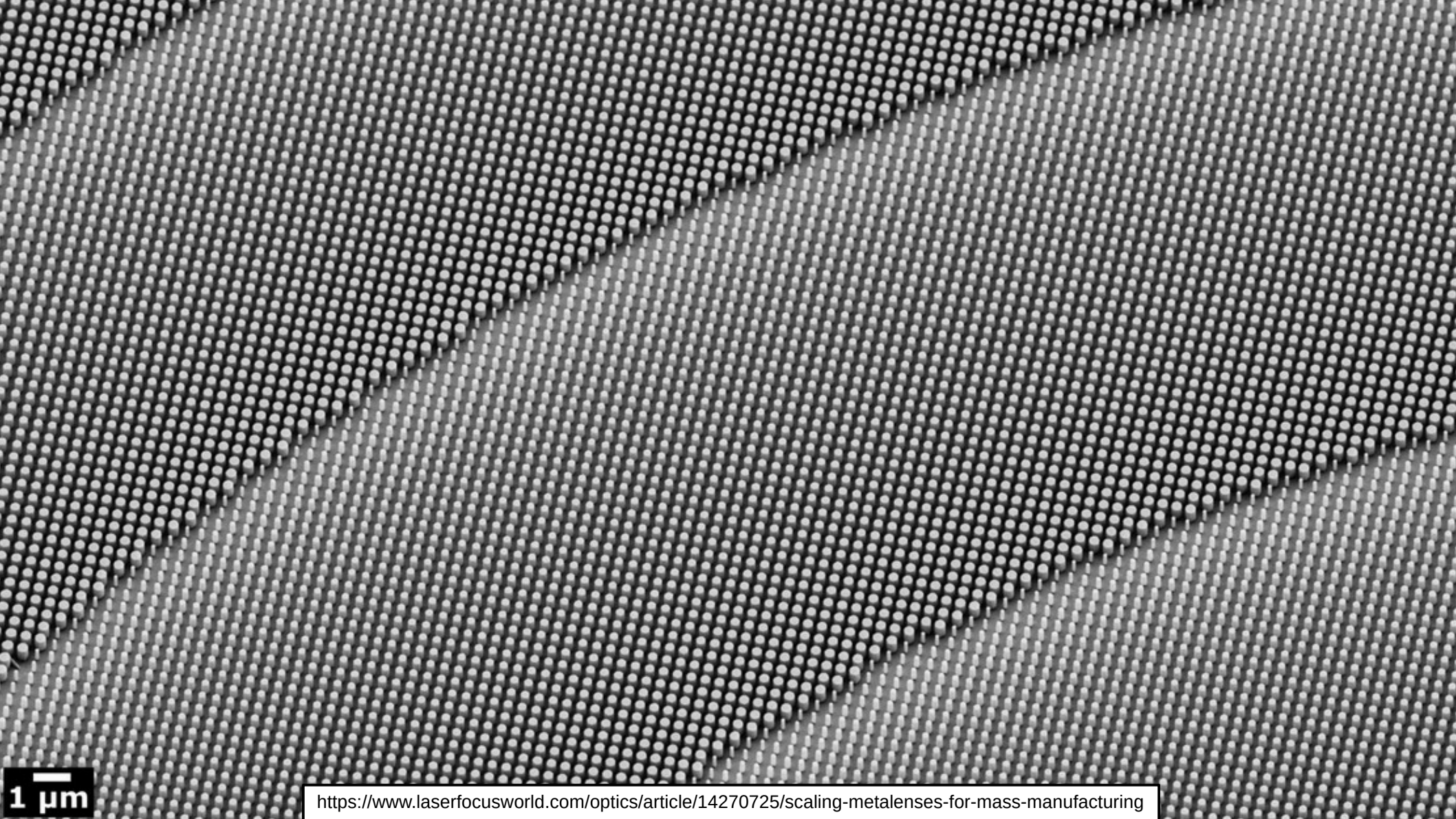
2π Phase Shift in Transmission with Dielectric Metasurfaces



Transmission properties



radius = 242 nm, height = 220 nm, period, period = 668 nm

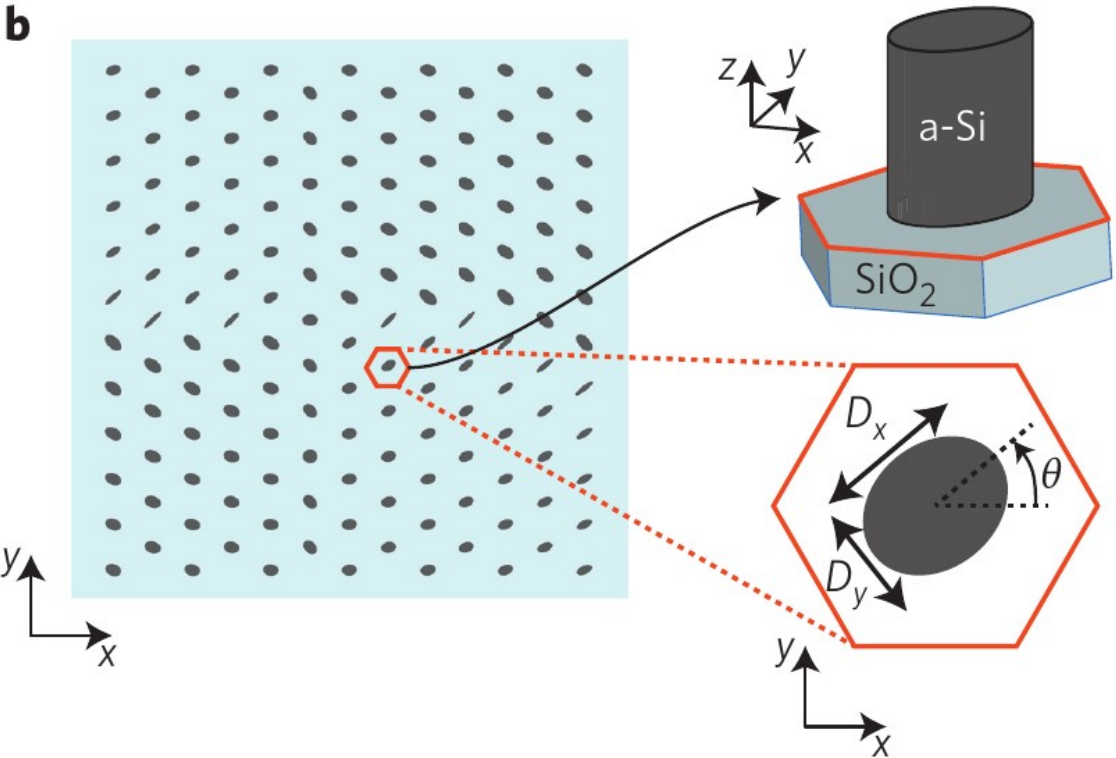


1 μm

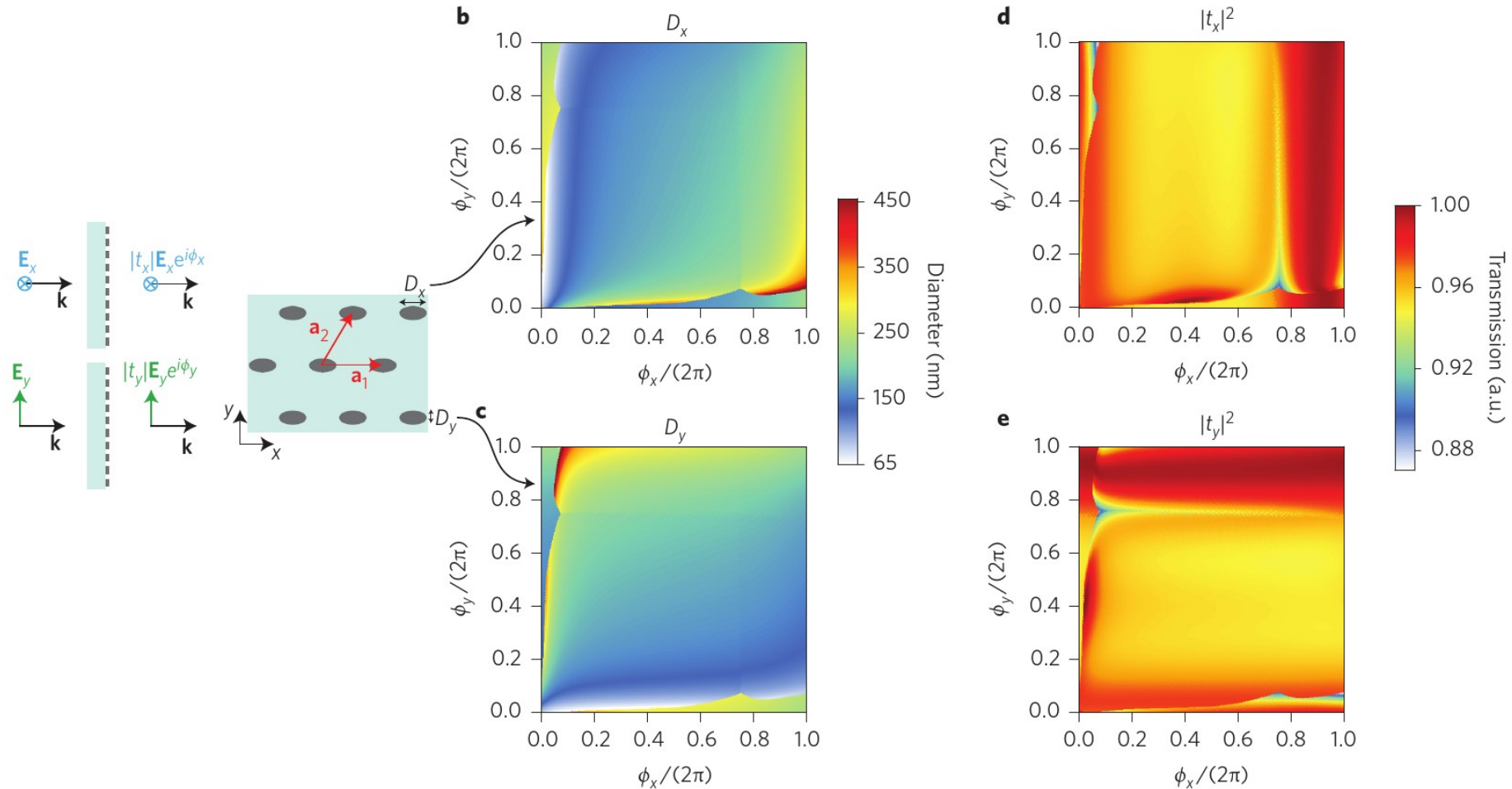
<https://www.laserfocusworld.com/optics/article/14270725/scaling-metalenses-for-mass-manufacturing>

Birefringent Control with Elliptical Resonators

Resonators with different dimensions along x and y allow controlling the transmission phase of TE and TM waves independently

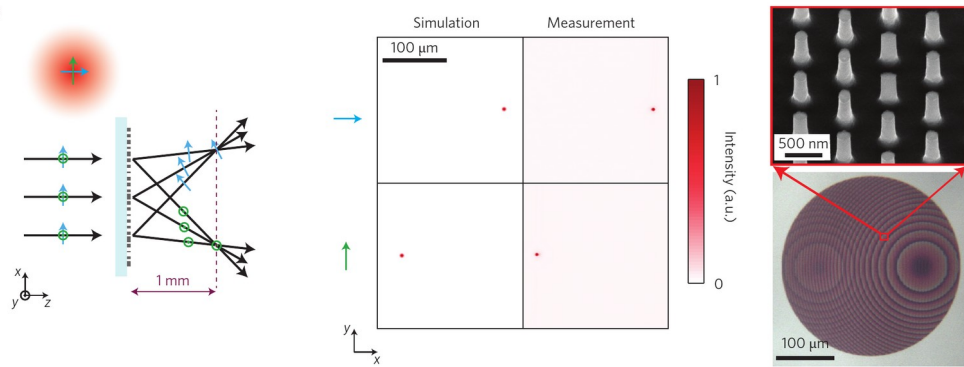


Birefringent Transmission Amplitude and Phase

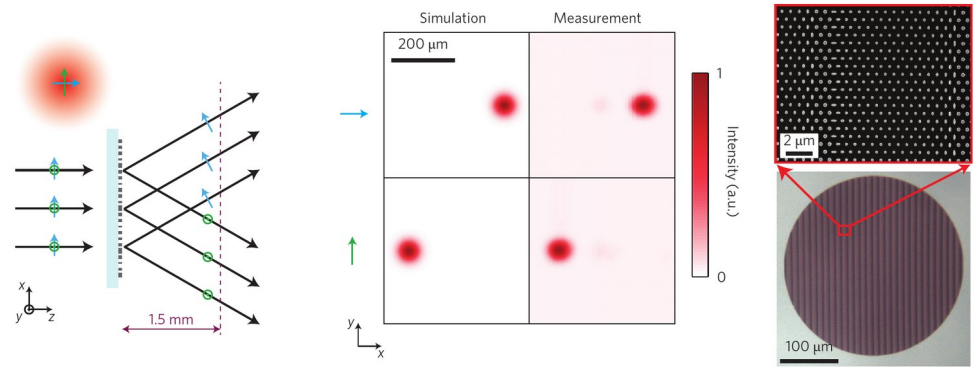


Birefringent Transformations

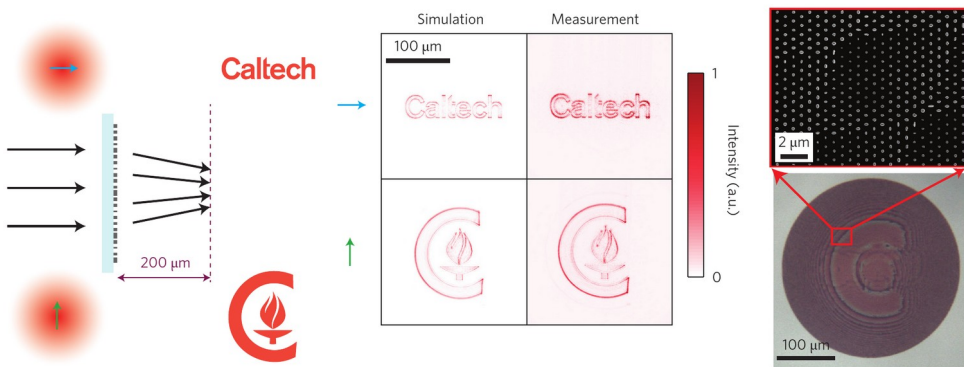
Different focus for TE and TM waves



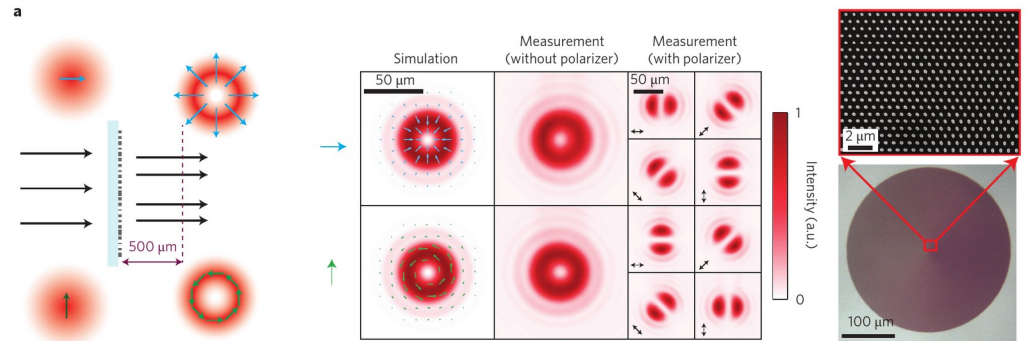
TE and TM beam splitting ($\pm 5^\circ$)



Different holograms for TE and TM waves

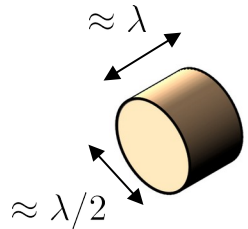


Vortex beam generation



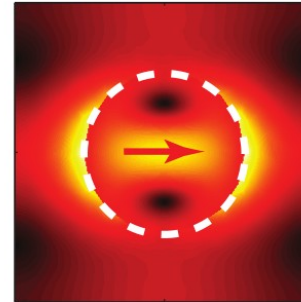
Controlling the Phase – Optical vs Microwave Regime

Dielectric resonators

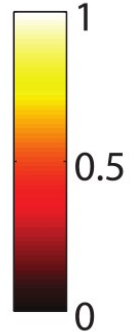
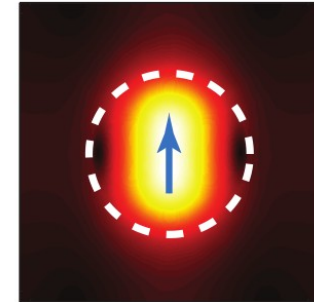


- Simple structure
- Limited control of fields
- Good at optical frequencies

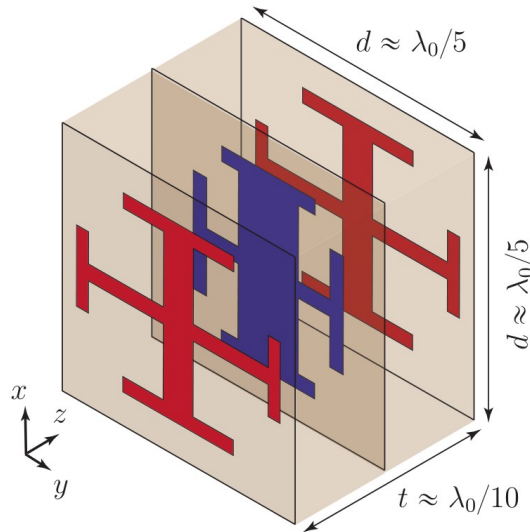
Electric field



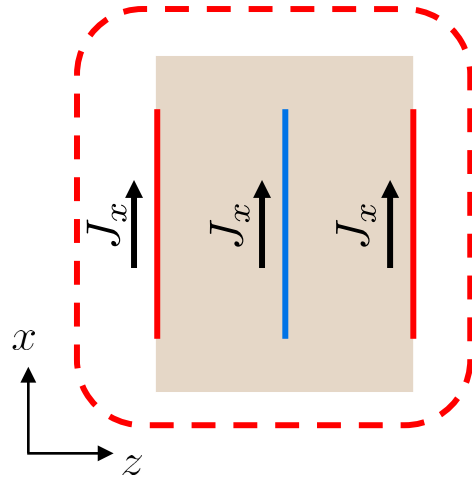
Magnetic field



Cascaded metallic layers

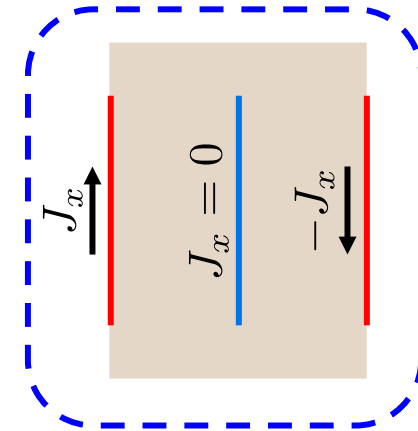


Even mode



Electric resonance

Odd mode



Magnetic resonance

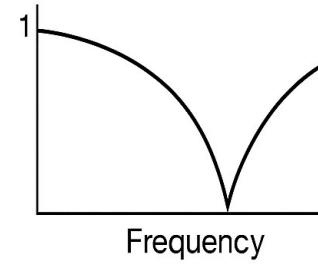
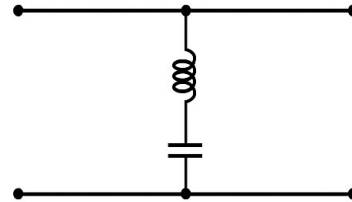
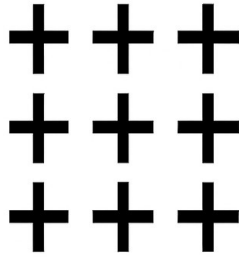
Screen vs Films

Elements

Equivalent
Circuit

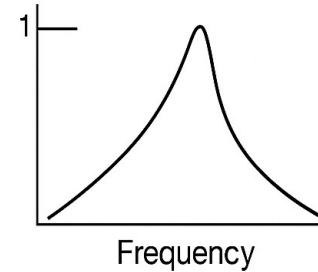
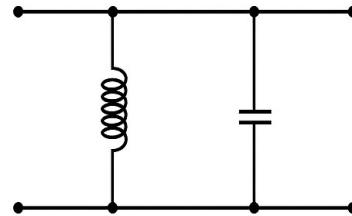
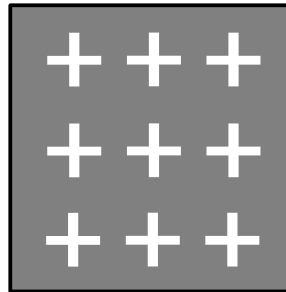
Transmission
Function

Crosses
(film)



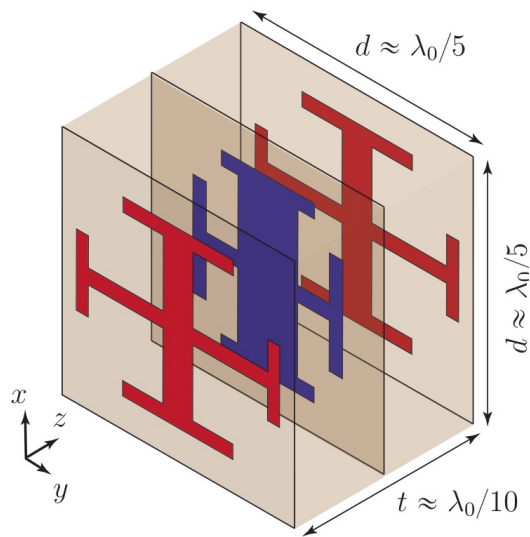
Band stop

Aperture crosses
(screen)

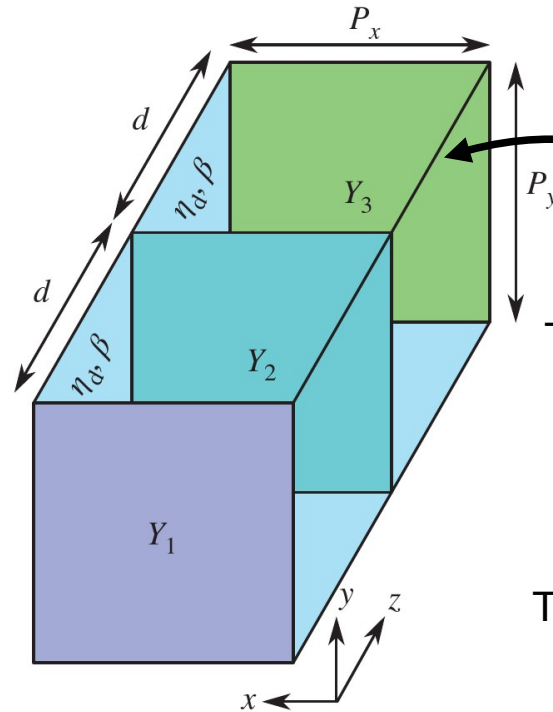


Band pass

Modeling the Structure Response



We assume that the outer layers are identical ($Y_1 = Y_3$)



Each metallic sheet is model as an impedance layer

$$\overline{\overline{Y}}_a = \begin{bmatrix} 1 & 0 \\ Y_a & 1 \end{bmatrix}$$

The dielectric spacers are modeled as

$$\overline{\overline{M}} = \begin{bmatrix} \cos(\beta d) & j\eta_d \sin(\beta d) \\ \frac{j \sin(\beta d)}{\eta_d} & \cos(\beta d) \end{bmatrix}$$

The ABCD matrix of the entire structure

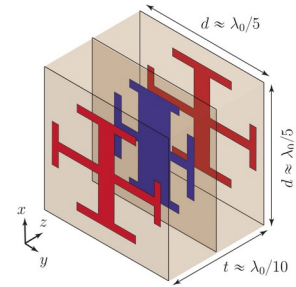
$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \overline{\overline{Y}}_1 \cdot \overline{\overline{M}} \cdot \overline{\overline{Y}}_2 \cdot \overline{\overline{M}} \cdot \overline{\overline{Y}}_1$$

The ABCD matrix is mapped to the scattering parameters using

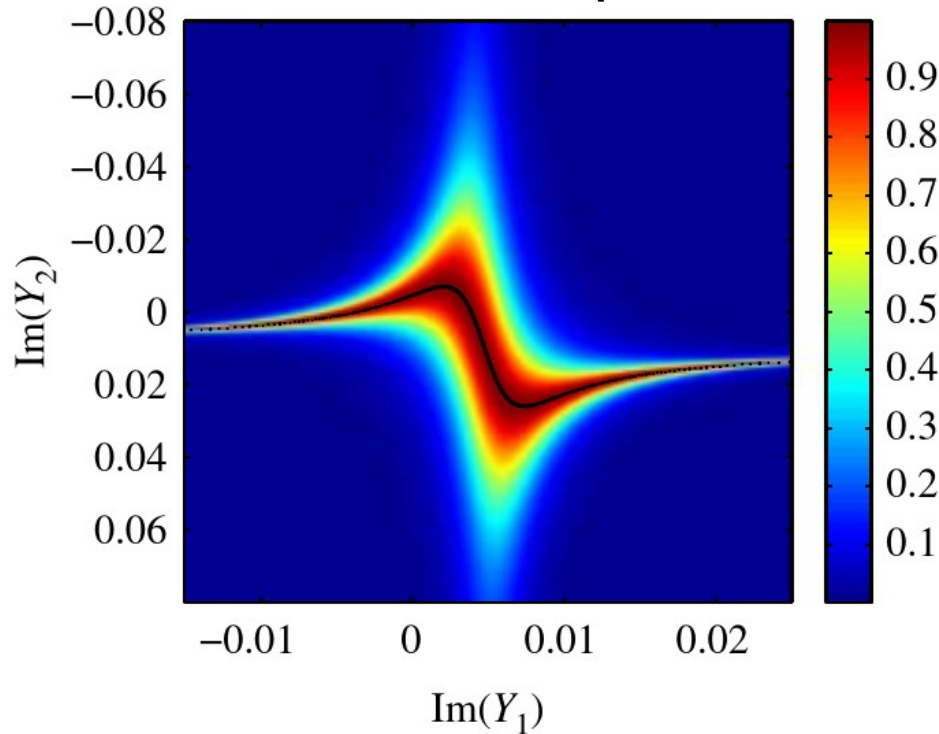
$$\begin{bmatrix} S_{11} & S_{12} \\ S_{21} & S_{22} \end{bmatrix} = \frac{1}{2A + B/\eta_0 + C\eta_0} \begin{bmatrix} B/\eta_0 - C\eta_0 & 2 \\ 2 & B/\eta_0 - C\eta_0 \end{bmatrix}$$

Scattering Response

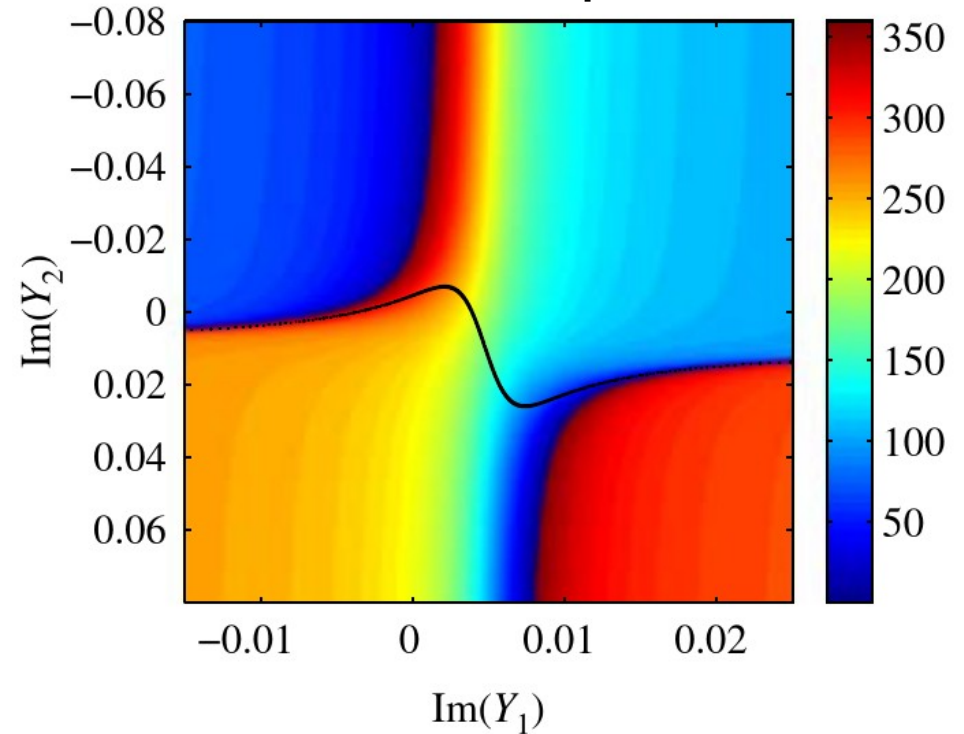
Changing the shape (admittance Y_a) of the middle and outer layers allows achieving 2π phase shift with full transmission



Transmission amplitude



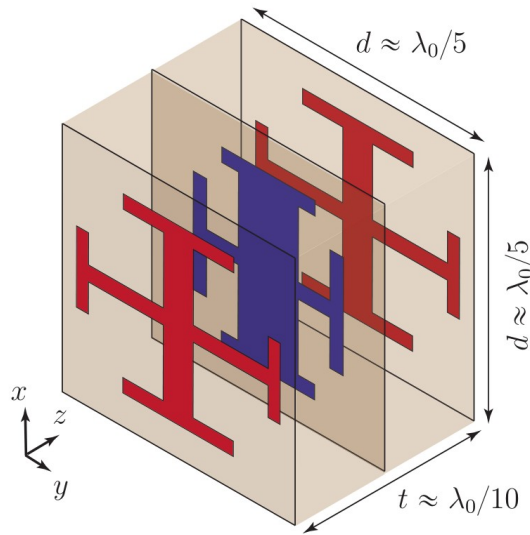
Transmission phase



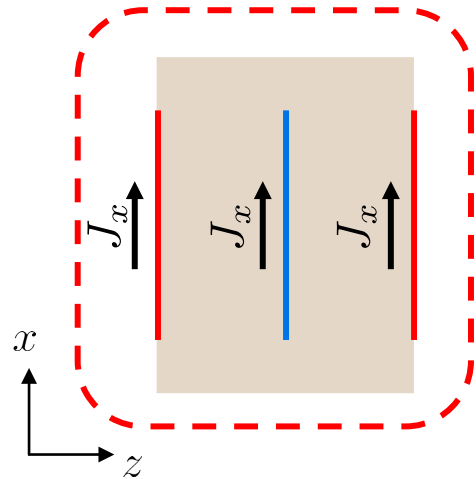
Note: lossless metallic sheets are modeled with imaginary admittances

Controlling Electric and Magnetic Responses Independently

Cascaded metallic layers

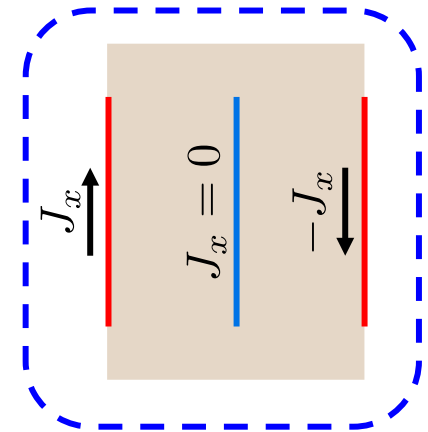


Even mode



Electric resonance

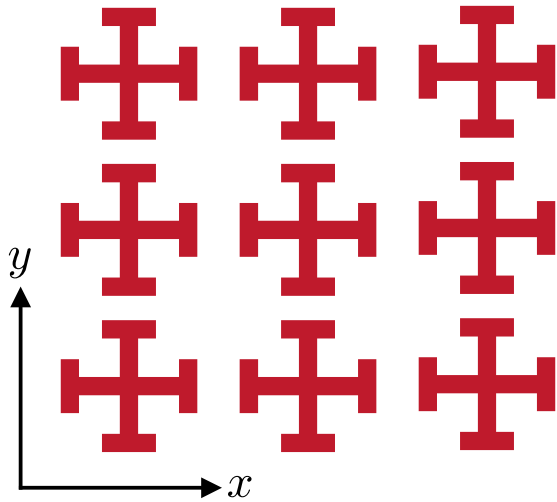
Odd mode



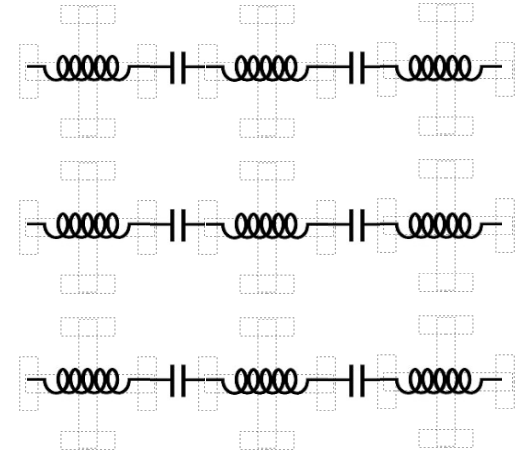
Magnetic resonance

Since the current is zero on the middle layer for the magnetic resonance, the middle layer can be used to control the electric response with affecting the magnetic response. One can start by adjusting the outer layers to control the magnetic response and then adjust the middle layer to control the electric response.

Lump Element Model



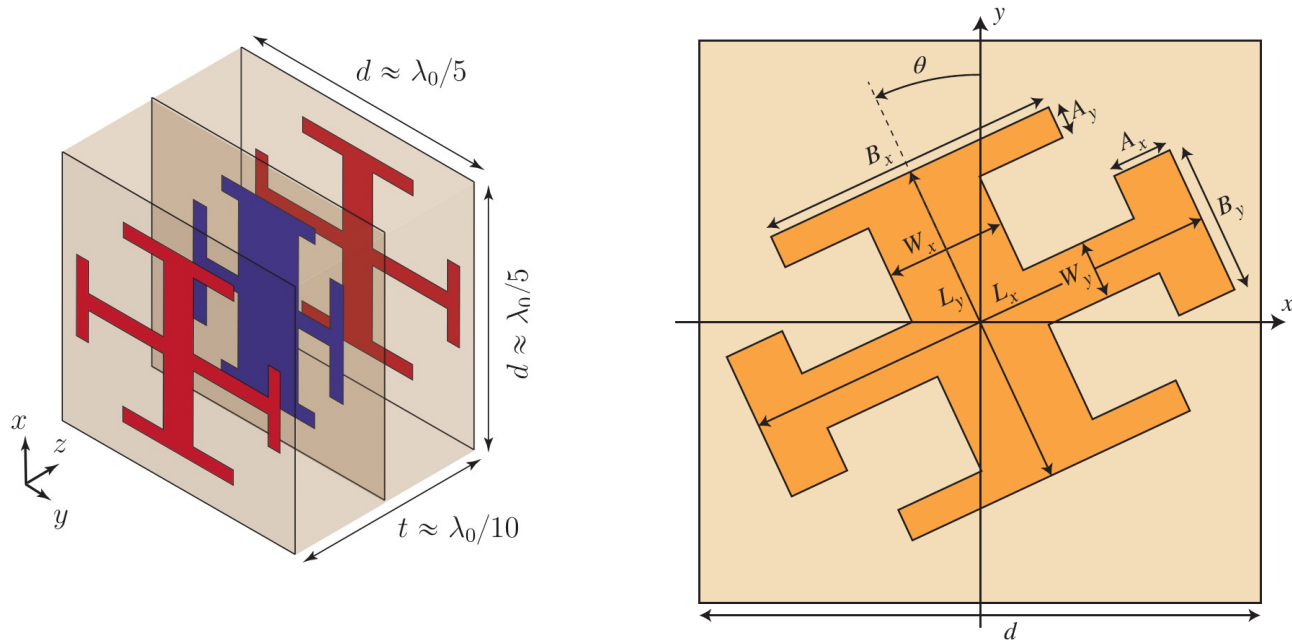
For x polarization



Increasing the length of the cross arms increases both the inductance and capacitance leading to a decrease of the resonance frequency

$$\omega = \frac{1}{\sqrt{LC}}$$

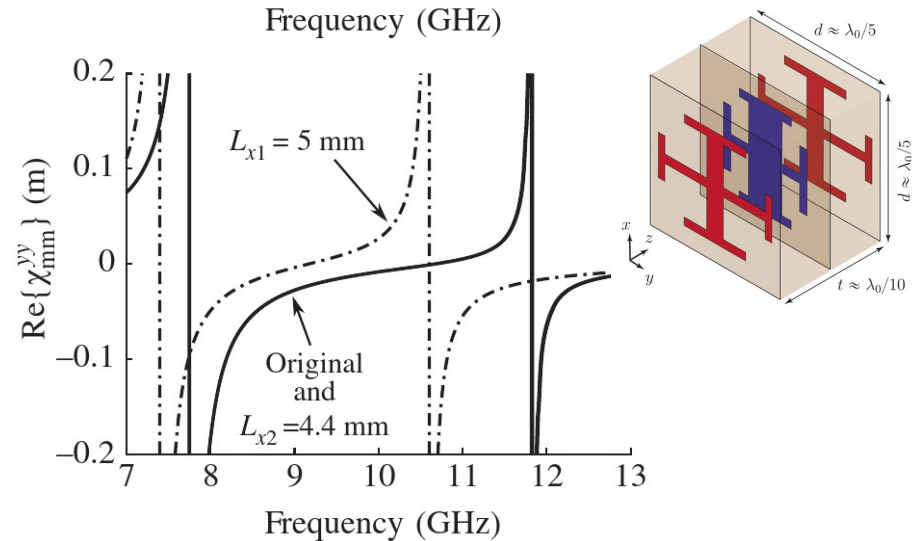
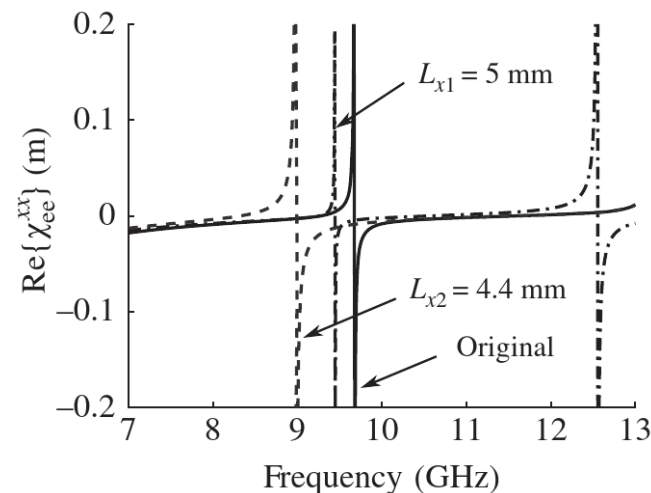
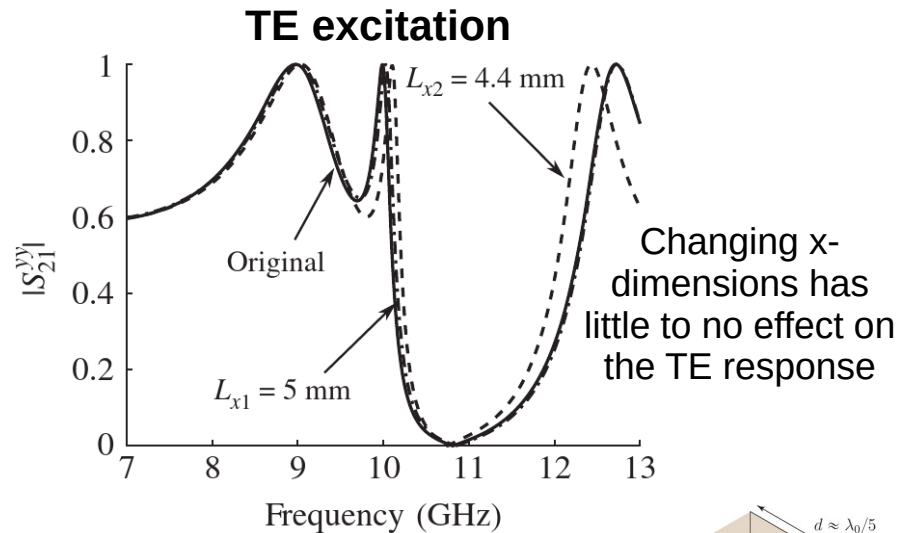
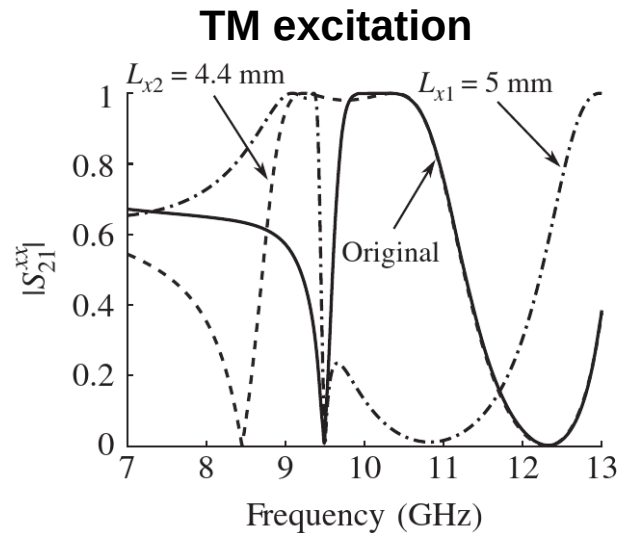
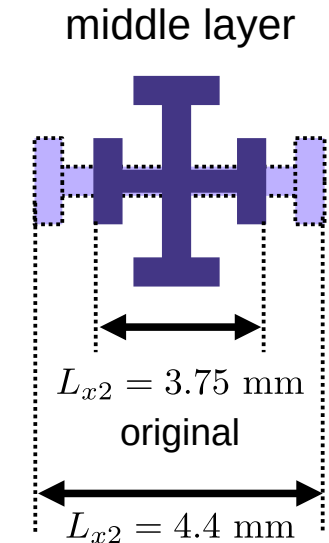
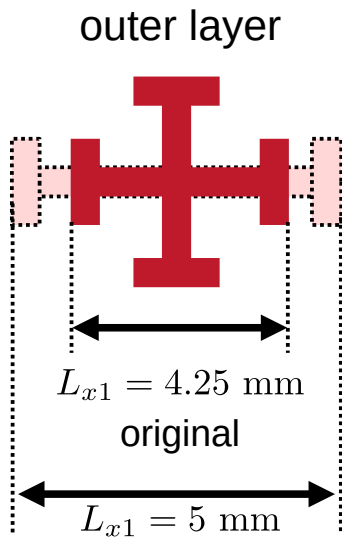
Controlling Electric and Magnetic Responses Independently



Layers dimensions in [mm] for $\theta = 0^\circ$

	L_x	L_y	W_x	W_y	A_x	A_y	B_x	B_y
Layer 1	4.25	4.75	0.625	0.25	0.5	0.5	4.25	3
Layer 2	3.75	5.25	0.5	0.375	0.5	0.5	2.25	4.5

Demonstration of Independent Control

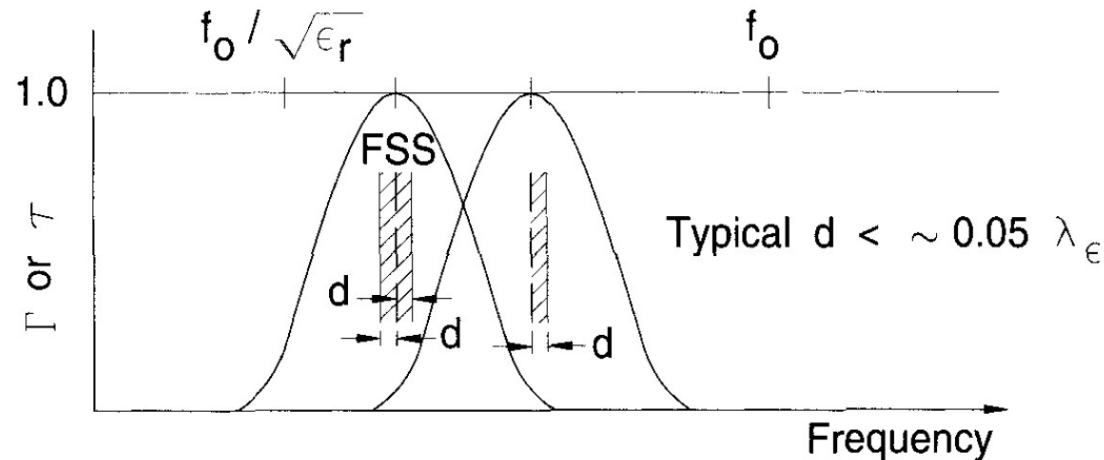
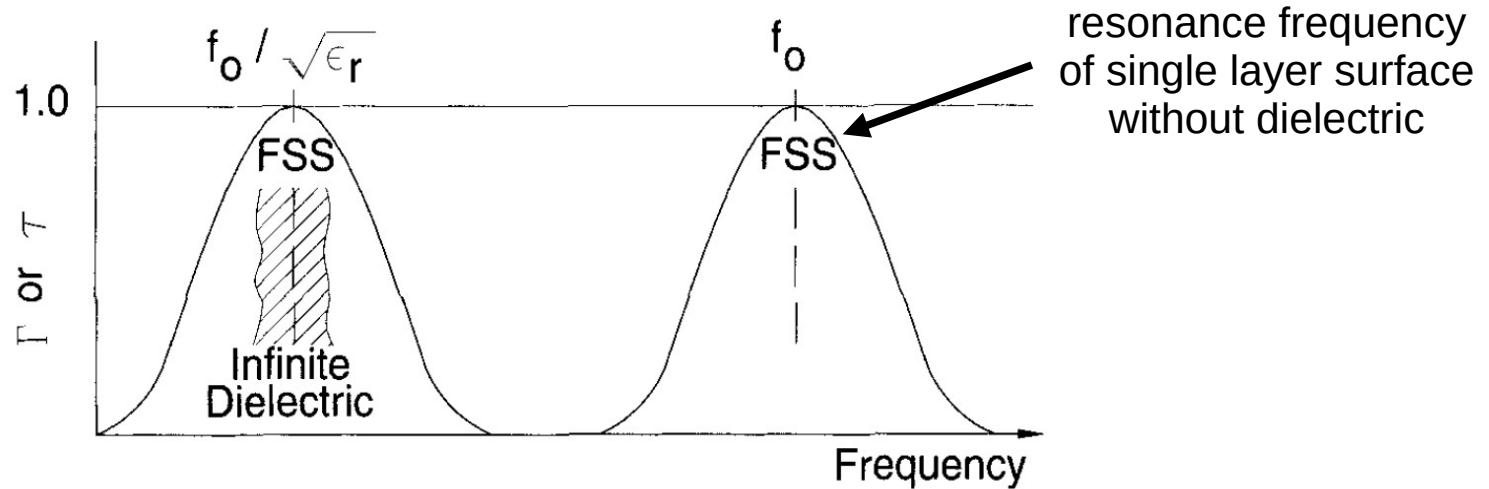


Effect of the Dielectric Spacers

The presence of a dielectric around the surface shifts the resonance to lower frequencies

The dielectric increases the stored electric energy (capacitance)

$$\omega = \frac{1}{\sqrt{LC}}$$

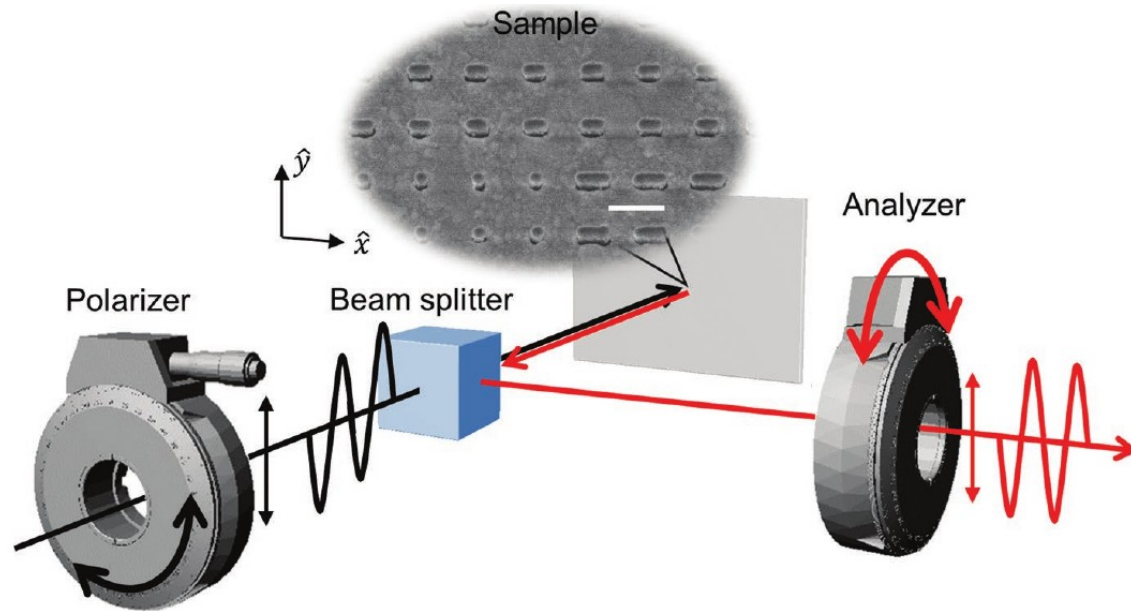


What Have We Learned So Far....

- The scattering response of both metallic and dielectric metasurface may be expressed in terms of interactions of electric and magnetic responses. These interactions can not only lead to the Kerker effect (canceling of the reflectance and maximization of the transmittance) but also to a 2π phase shift.
- Many dielectric metasurfaces have been realized with this approach by using elliptical high-index resonators that have the advantage of allowing the control of both x- and y-polarized waves.
- In the microwave regime, it is more common to use multilayer metallic structures typically having the shape of crosses for near independent birefringent control.
- A three-layer metallic structure with identical outer layers can be shown to exhibit full transmittance with full 2π phase coverage.
- Another advantage of this design is that it offers a very easy control of its electric and magnetic responses. The two outer layers can be used to control the magnetic response and the middle layer, which barely affects the magnetic response, may be used to control its electric response.

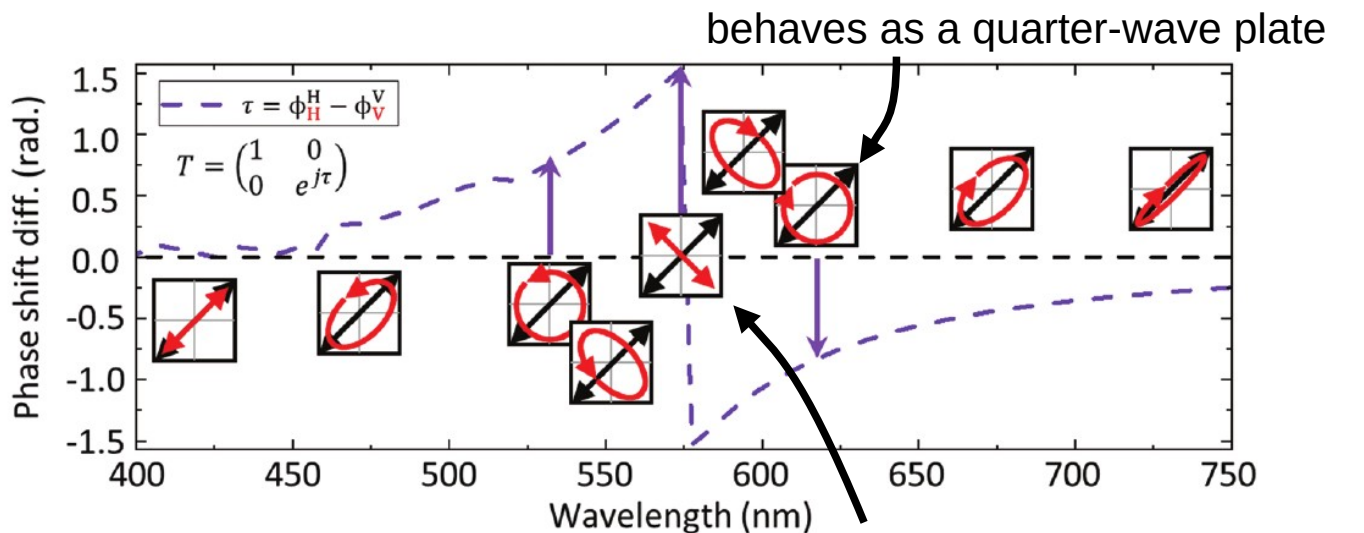
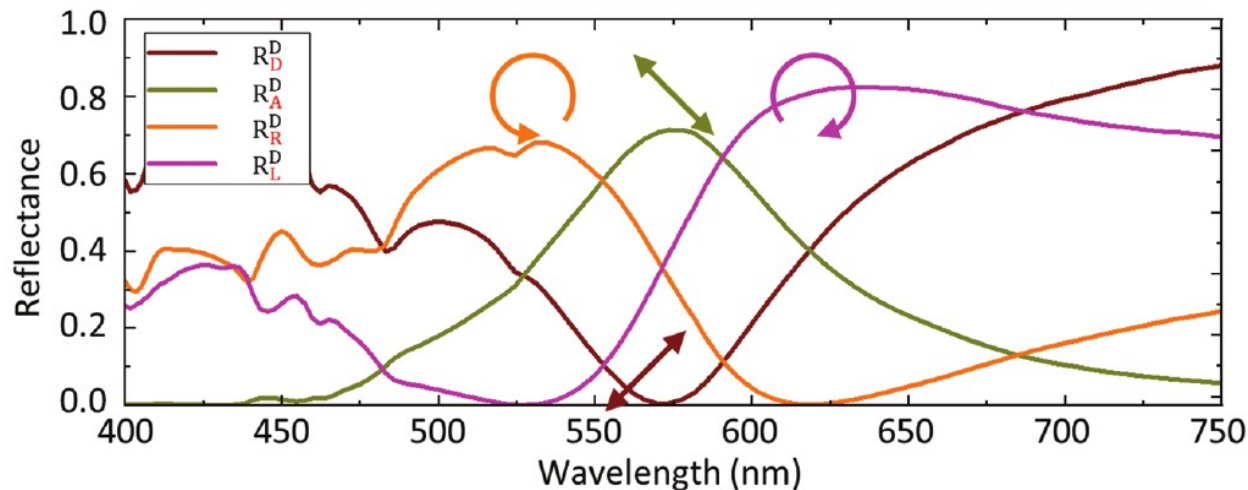
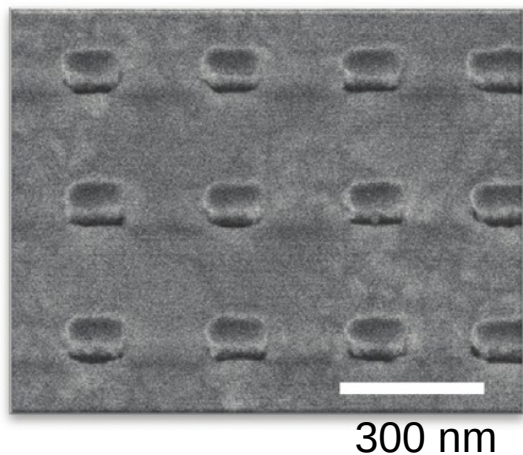
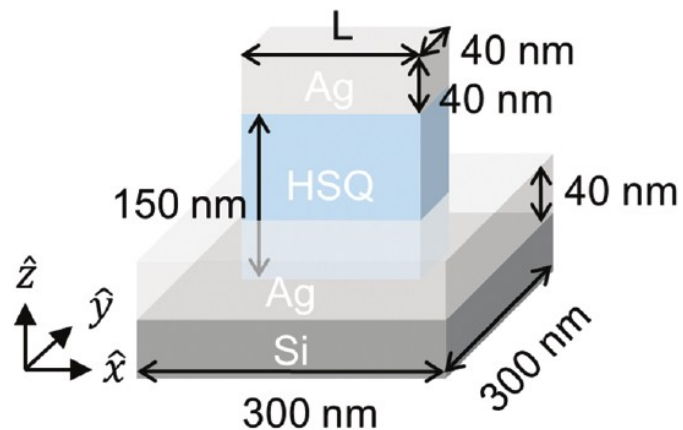
Wave Plate Control

Exploiting Rotation of Polarization

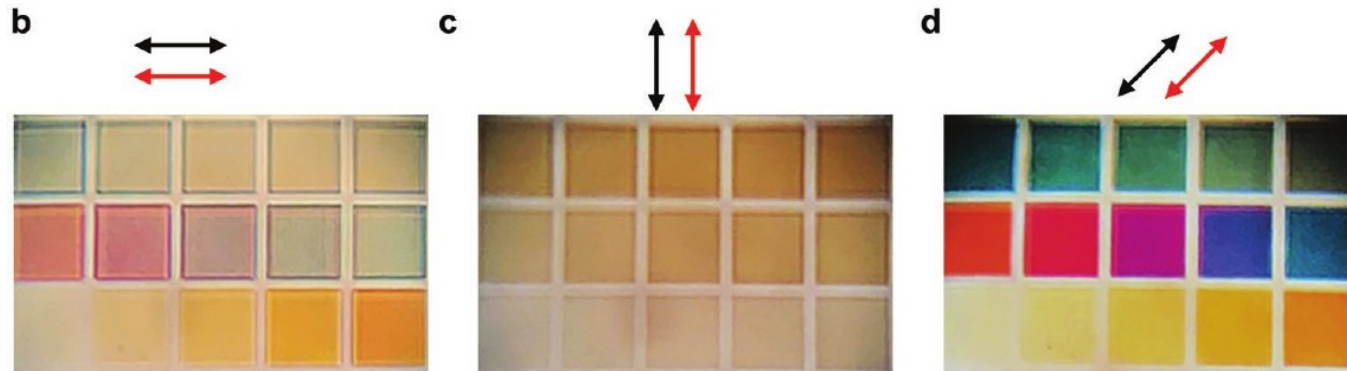
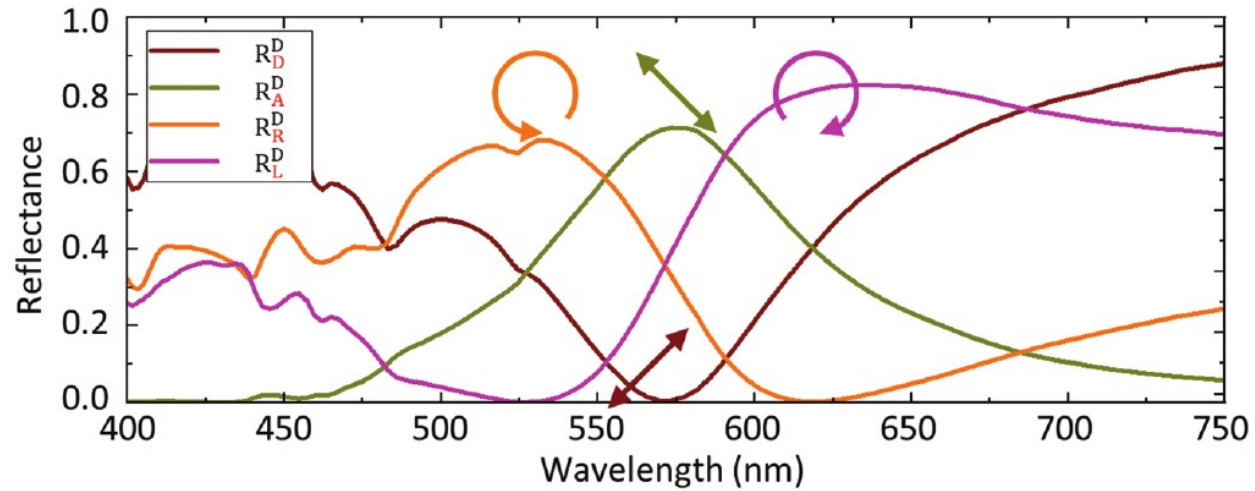


Black = illumination, **Red** = measurement

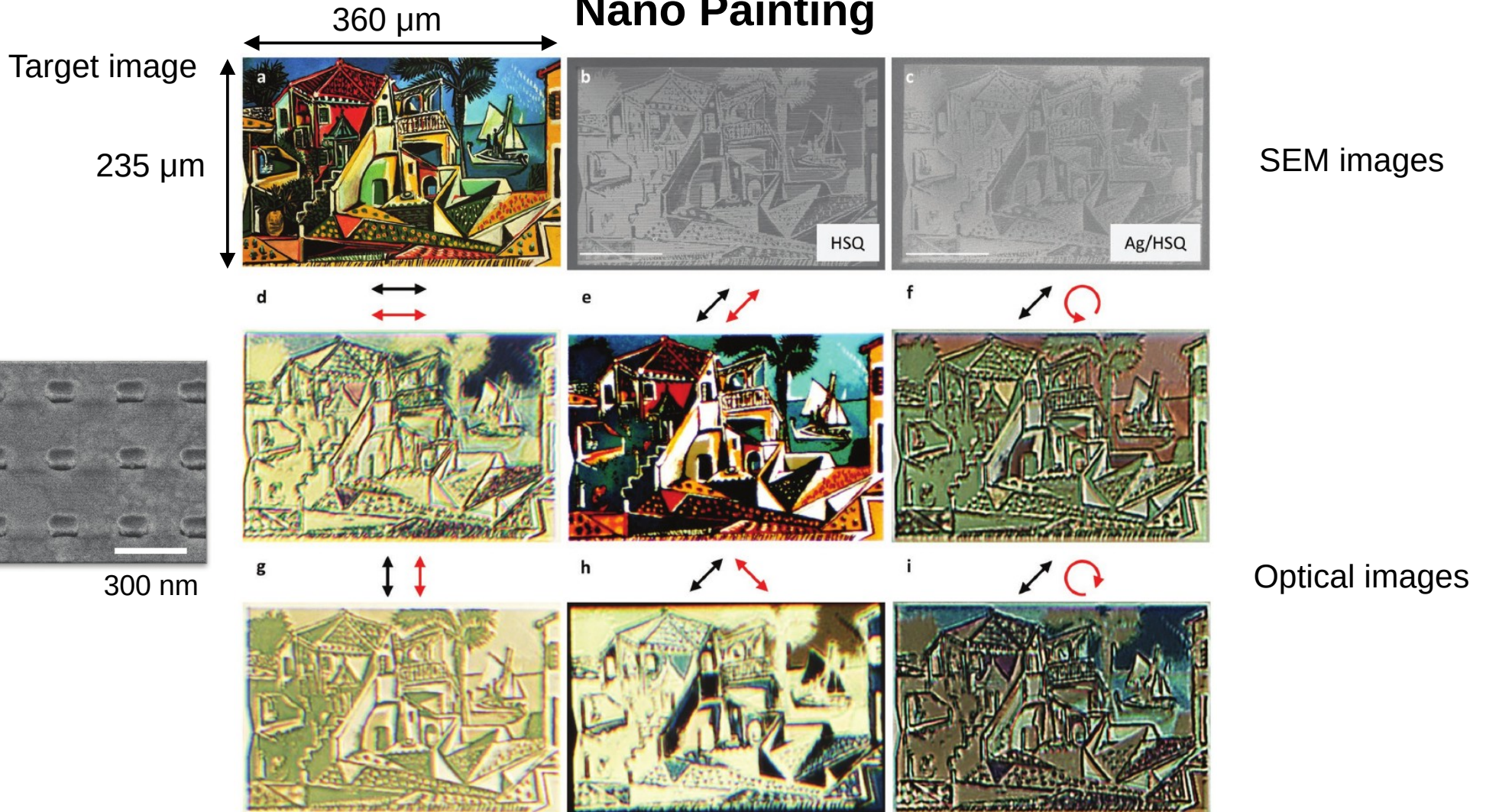
Exploiting Rotation of Polarization



Exploiting Rotation of Polarization

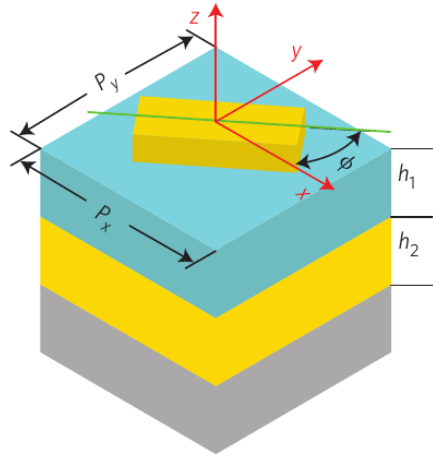


Nano Painting



Pancharatnam-Berry Effect

Pancharatnam-Berry Effect



Jones vector of the scattered wave

Jones vector of the incident wave

$$\mathbf{J}_s = \overline{\overline{\mathbf{R}}}(\theta) \cdot \overline{\overline{\mathbf{M}}}_{\text{HWP}} \cdot \overline{\overline{\mathbf{R}}}(-\theta) \cdot \mathbf{J}_i$$

LCP or RCP incident wave

$$\mathbf{J}_i = \begin{bmatrix} 1 \\ \pm j \end{bmatrix}$$

$$\mathbf{J}_s = e^{j2\theta} \begin{bmatrix} 1 \\ \mp j \end{bmatrix}$$

The polarization of the scattered wave is flipped

Rotation matrix

$$\overline{\overline{\mathbf{R}}}(\theta) = \begin{bmatrix} \cos \theta & -\sin \theta \\ \sin \theta & \cos \theta \end{bmatrix}$$

Jones matrix of a half-wave plate

$$\overline{\overline{\mathbf{M}}}_{\text{HWP}} = \begin{bmatrix} 1 & 0 \\ 0 & -1 \end{bmatrix}$$

Reflective Metasurface Based on PB Phase

Parameters

$$P_x = P_y = 300 \text{ nm}$$

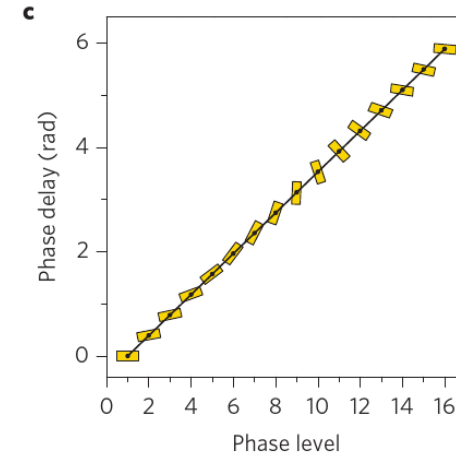
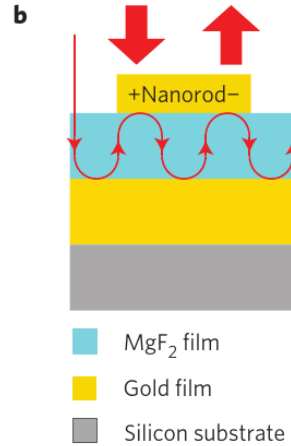
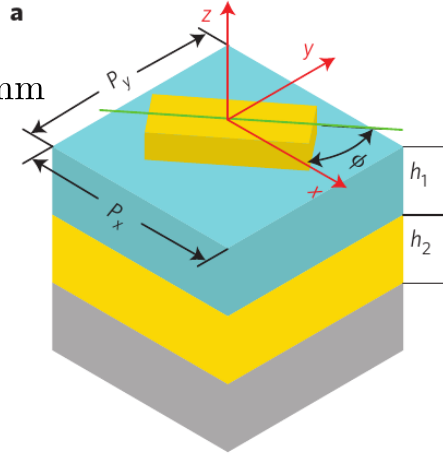
$$h_1 = 90 \text{ nm}$$

$$h_2 = 130 \text{ nm}$$

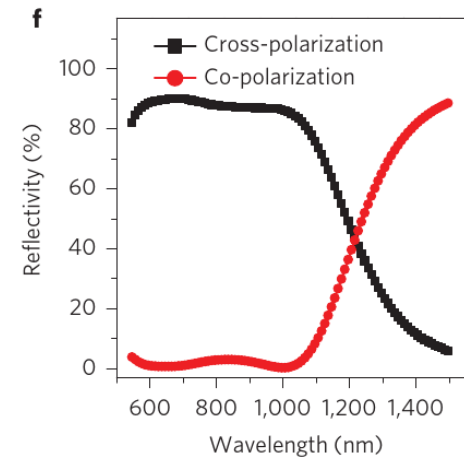
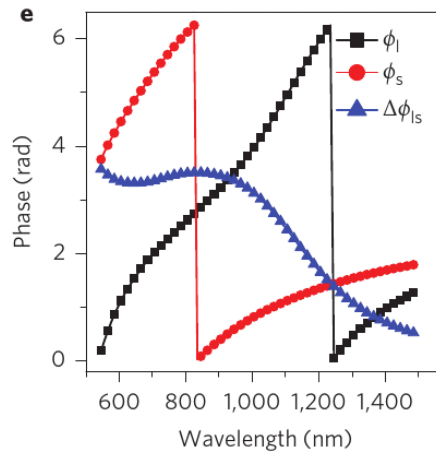
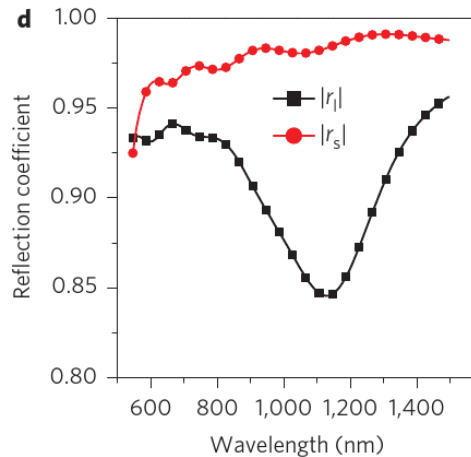
$$L = 200 \text{ nm}$$

$$W = 80 \text{ nm}$$

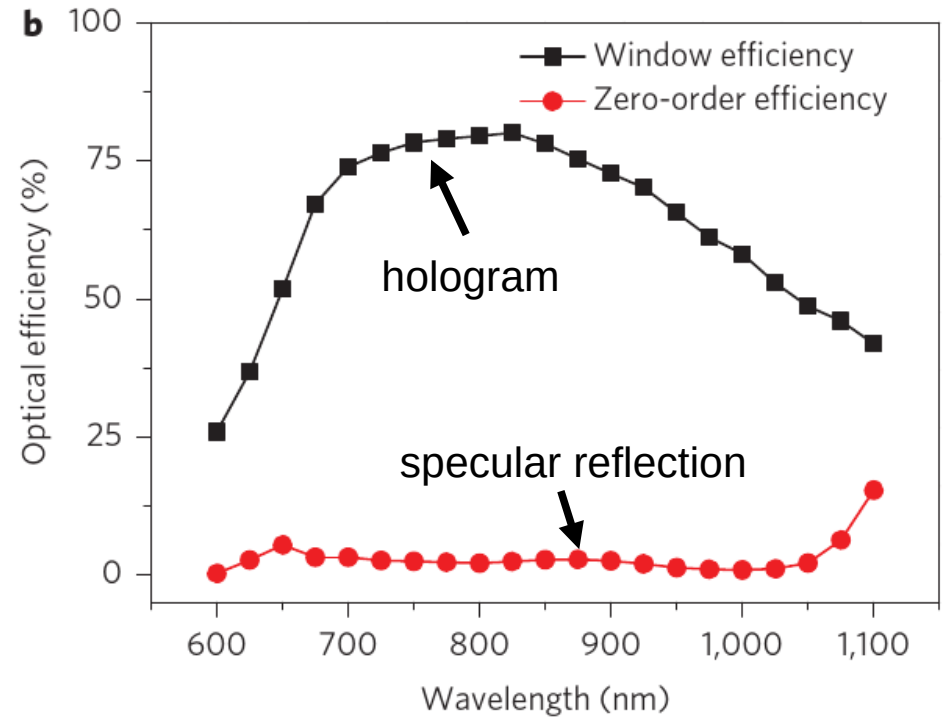
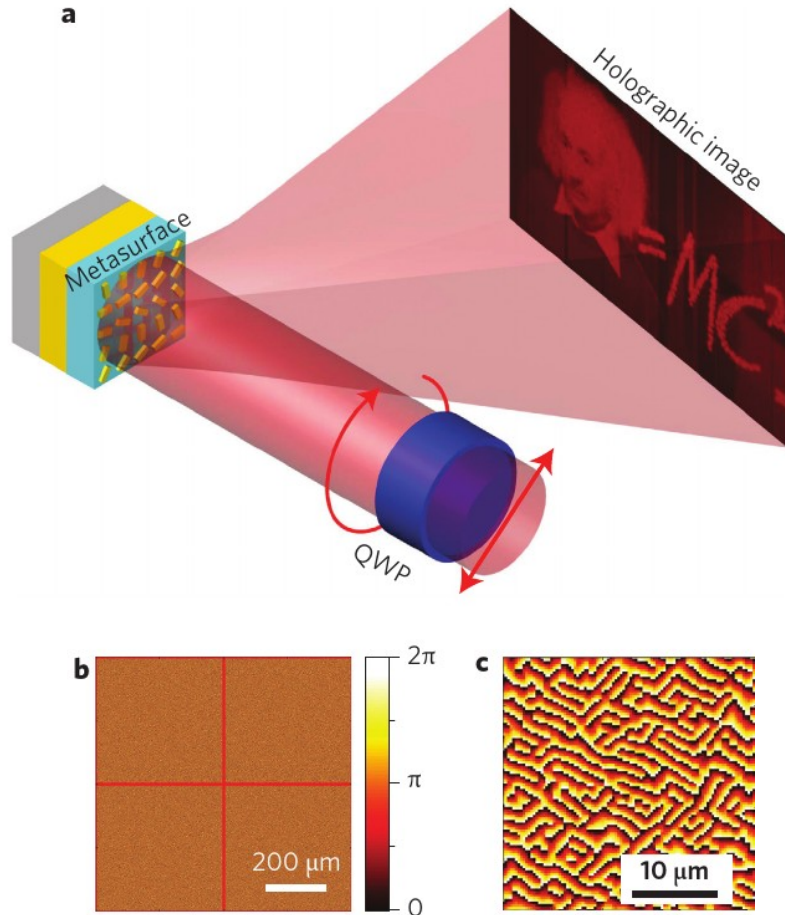
$$H = 30 \text{ nm}$$



$$\mathbf{J}_t = e^{j2\theta} \begin{bmatrix} 1 \\ \mp j \end{bmatrix}$$

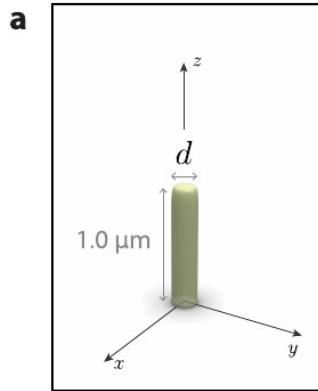


Hologram Efficiency Reaching 80%

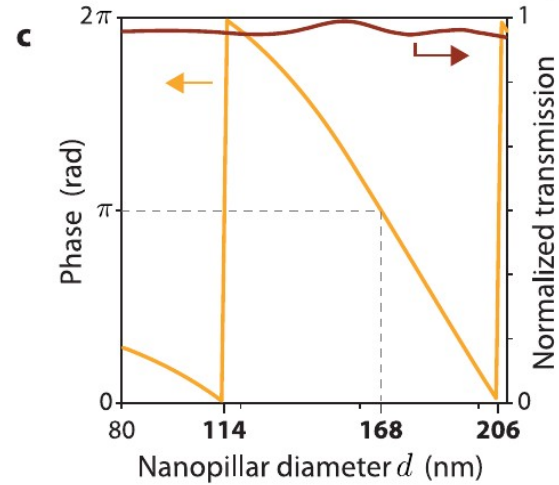
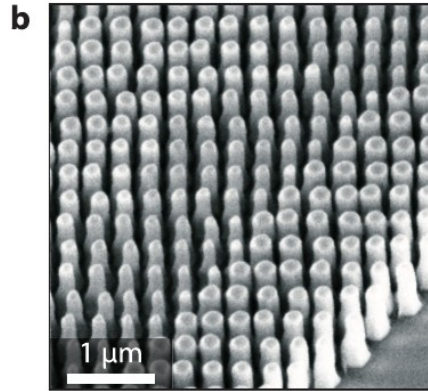


Example in Transmission

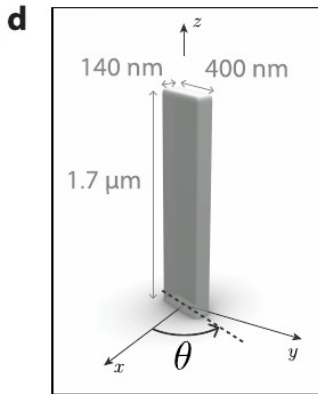
Effective-refractive-index metasurface



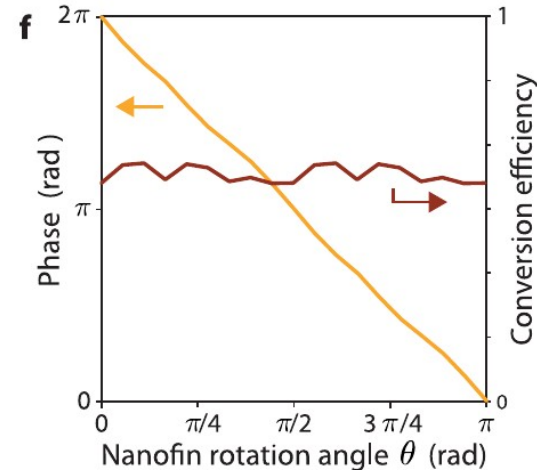
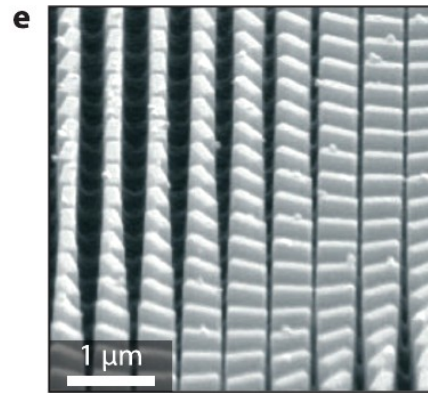
GaN nanopillar



Pancharatman-Berry metasurface



Polymer nanofin
ma-N 2410



Detour Phase

Detour Phase

A diffraction grating of period P produces ± 1 orders at angles

$$\sin \theta = \frac{\lambda}{P}$$

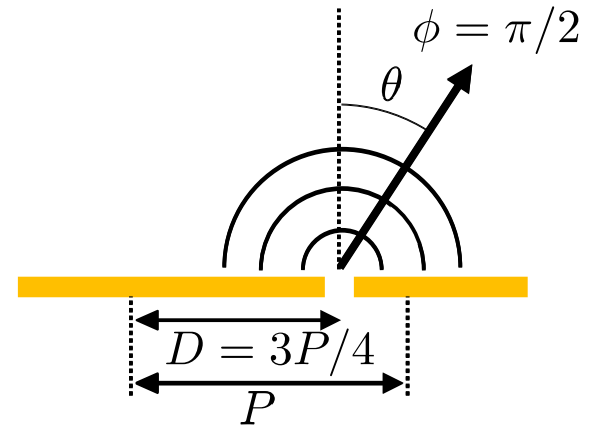
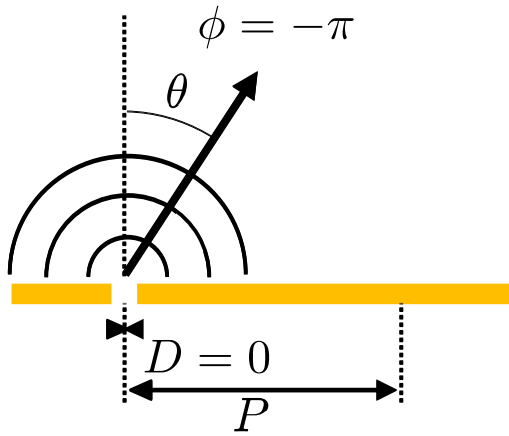
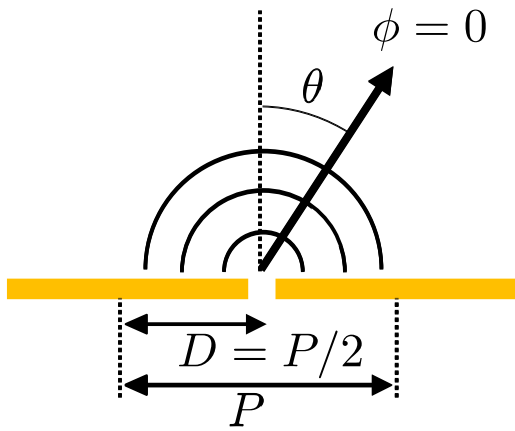
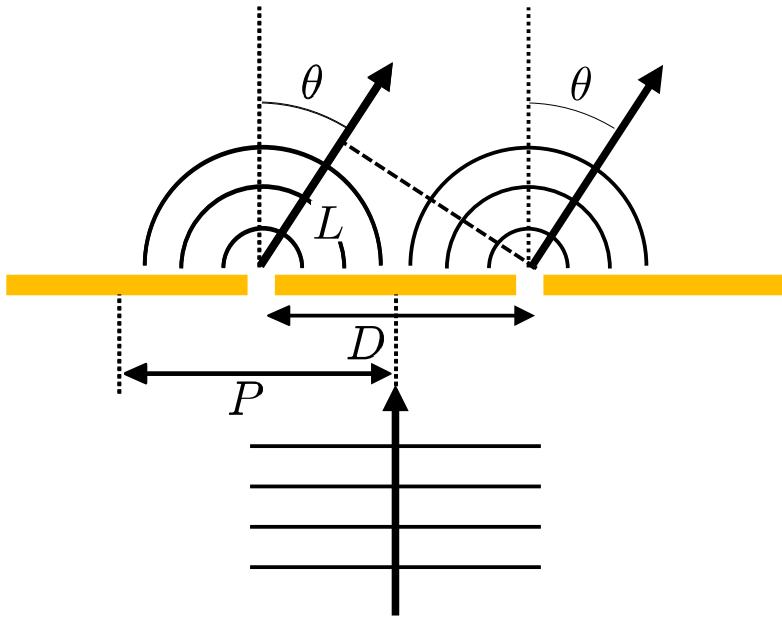
The path difference between the two beams emerging from slits separated by a distance D is

$$L = D \sin \theta$$

The phase shift between the two beams is

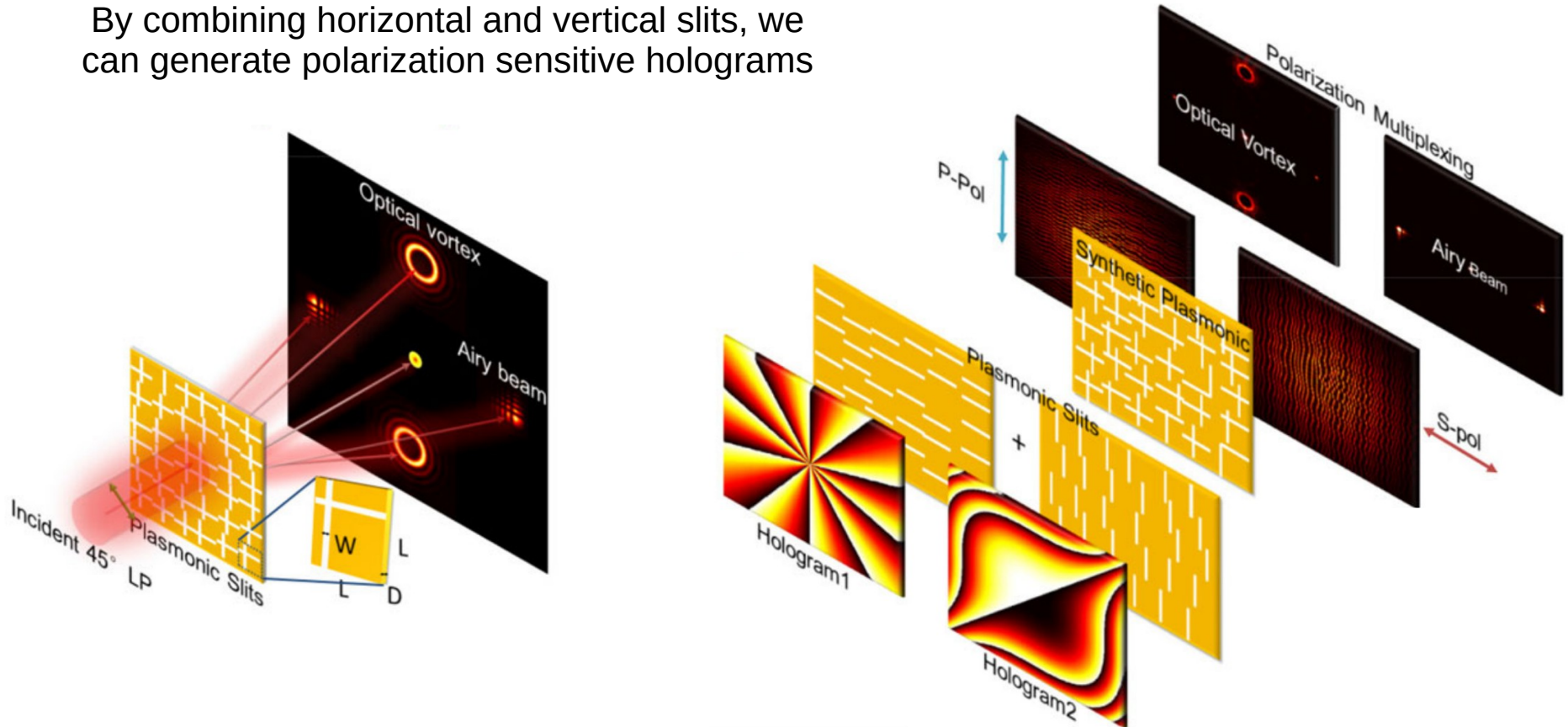
$$\Delta\phi = kL = \frac{2\pi}{\lambda} D \sin \theta$$

Choosing that the phase shift is zero for a slit in the middle of its period, we can cover the range $\pm\pi$

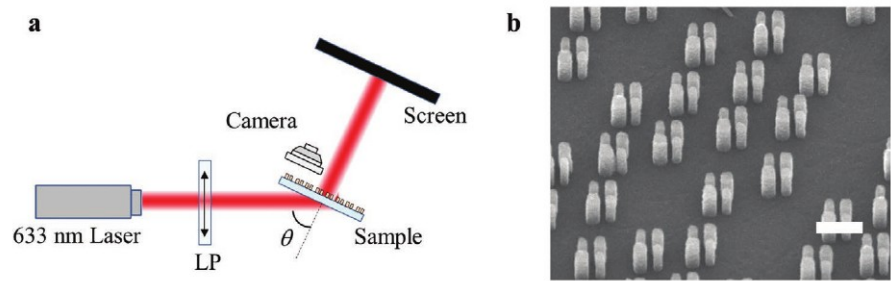
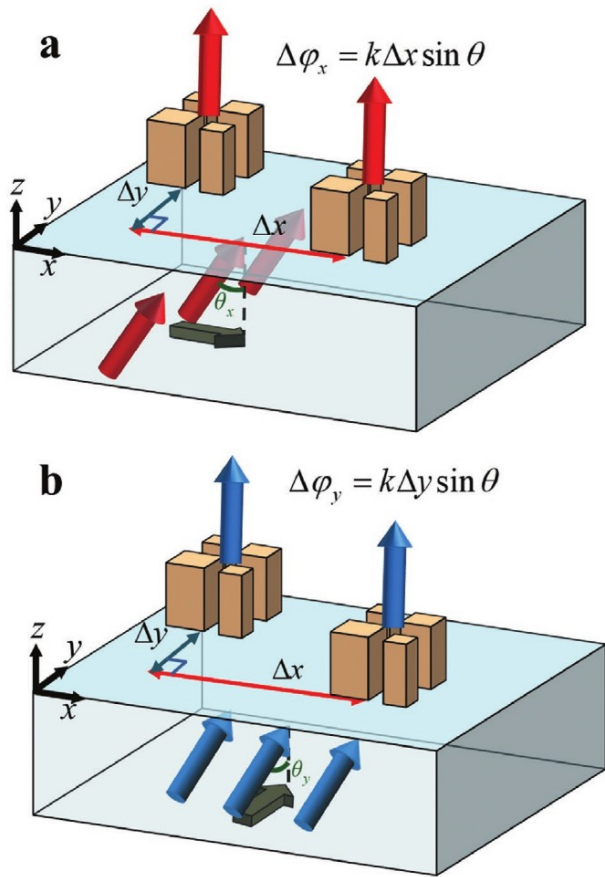


Polarization Sensitive Holography Using Detour Phase

By combining horizontal and vertical slits, we can generate polarization sensitive holograms



Example with Oblique Incidence and Normal Transmission



(θ_x, θ_y)	Simulation	Experiment
c $(64.7^\circ, 0)$	MUX	MUX
d $(0, 64.7^\circ)$	META	META

What Have We Learned So Far....

- Birefringent metasurfaces maybe used to create very differently looking optical structures when the polarization of the incident and scattered light are tuned.
- A half-wave plate (HWP) changes the handedness of circularly polarized light.
- A rotation of the HWP in the metasurface plane leads to phase shift of the scattered light.
- This allows to easily create a large amount of phase discretization leading to high efficiency holograms.
- HWP metasurfaces can be used in both reflection and transmission. The technique is however limited to circularly polarized light.
- An other approach for controlling the phase is via the “detour phase” technique.
- The detour phase technique consists in shifting the lateral position of the scattering element within its unit-cell. Depending on the angle of scattering and the angle of incidence, this lateral shift leads to a phase shift of the scattered light.